

MEXTRAM (level 504)

the Philips model for bipolar transistors

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FSA modeling workshop 2002

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■ History

■ Modelled effects

some basic bipolar characteristics

■ Improved description of output conductance and f_T

How an improved description gives smoother behaviour

■ Some optional features:

The effect of a graded Ge content in the base

Neutral base recombination

Self-heating

Advanced avalanche modelling: snapback

■ Geometric scaling

■ Status of Mextram 504

History

- **Mextram has been developed by Philips Research**
- **Physics based, suitable for digital and analog applications**
- **Introduced in 1985**
- **Updates**
 - **level 502: 1987**
 - **level 503: 1993**
 - **level 504: 2000**
- **In public domain since 1995**

http://www.semiconductors.philips.com/Philips_Models

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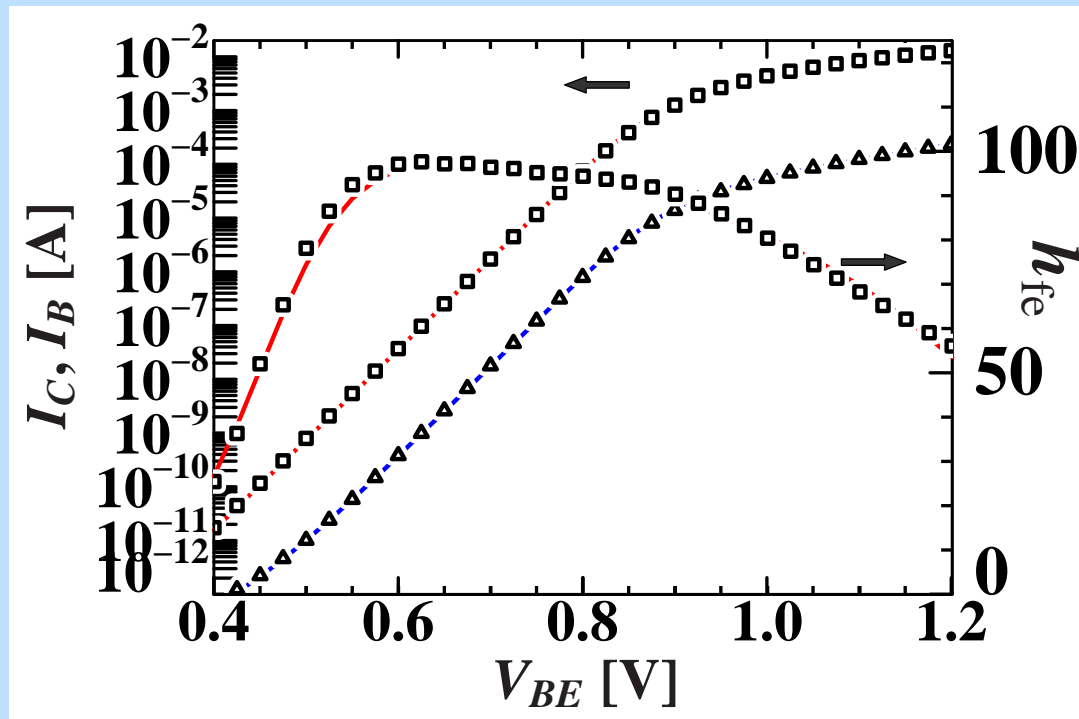
Advanced avalanche modelling: snapback

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Modelled effects: Gummel plot

Collector current, base current and current gain

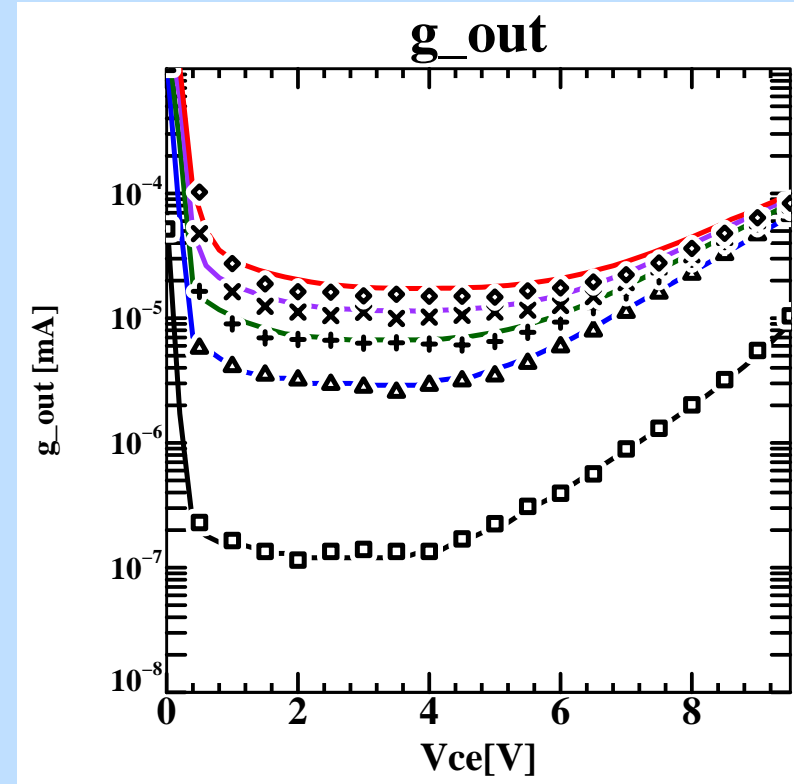
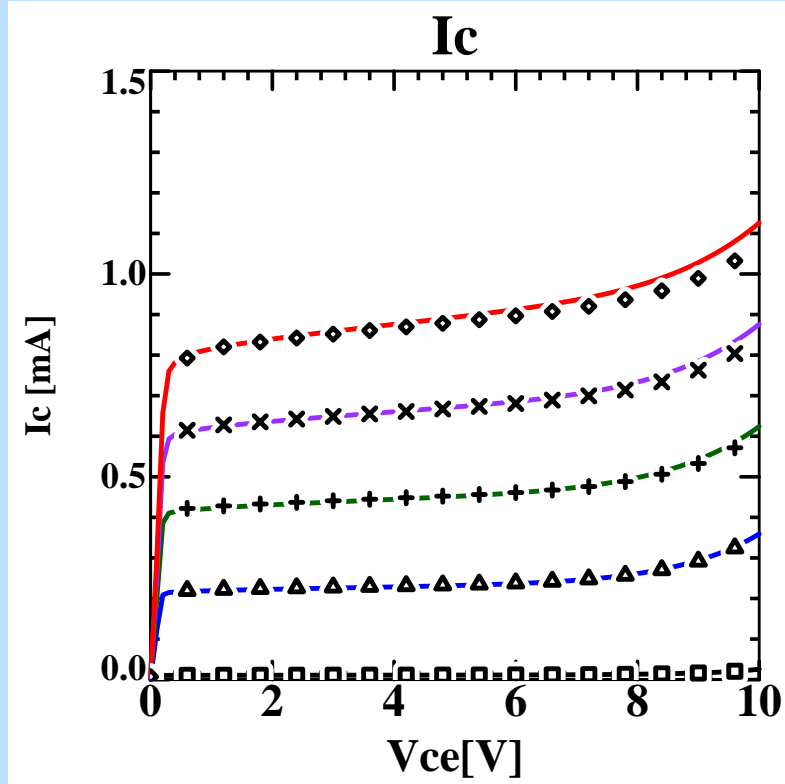


Non-ideal base current ($V_{BE} < 0.55$ V)

Bias dependent reverse Early effect (o.a. in h_{fe} : $V_{BE} = 0.5-0.9$ V)

High current effects (resistances, knee, Kirk effect) ($V_{BE} > 0.9$ V)

Modelled effects: Output characteristic



Bias dependent Early effect (g_{out} not constant)

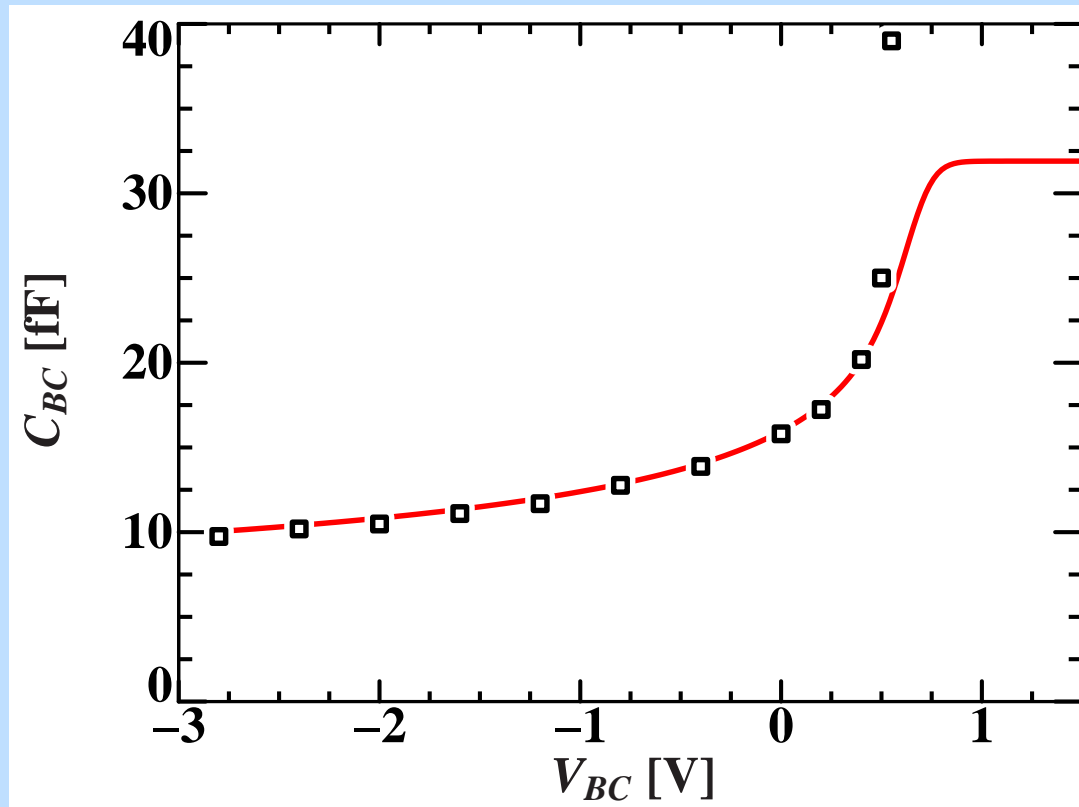
**Quasi-saturation/Kirk effect: current reduction at lower voltages/
high current densities**

Hard saturation ($V_{CE} < 0.6V$)

Avalanche ($V_{CE} > 4V$)

Depletion capacitances

Depletion capacitances in Mextram:



When diffusion charge becomes important ($V_{BC} > 0.5V$):
depletion capacitance levels off (not important anymore)

Diffusion charges

Spice-Gummel-Poon: as function of **current**

$$Q_{\text{diff}} = \tau_f I_f$$

Mextram: as function of **carrier densities**

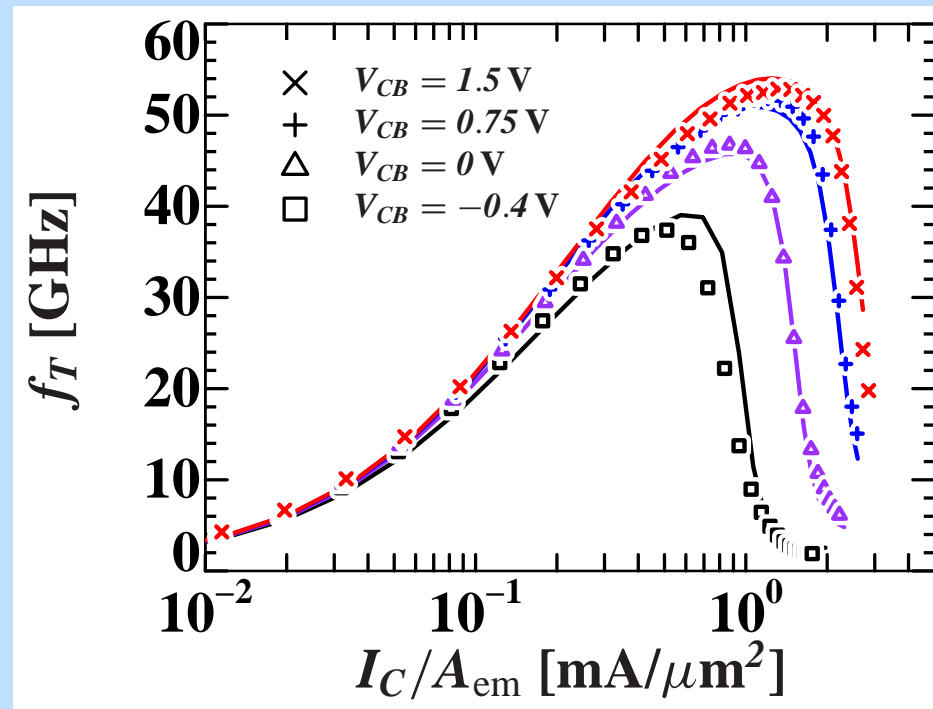
$$Q_{\text{diff,E}} = \tau_E I_s e^{V_{BE}/m_\tau V_T}$$

$$Q_{\text{diff,B}} = \frac{1}{2} Q_{B0} \quad (n_0 + n_B) \propto \tau_B$$

$$Q_{\text{diff,epi}} = \frac{1}{2} Q_{\text{epi0}} \frac{x_i}{W_{\text{epi}}} p_0 \quad \propto \tau_{\text{epi}}$$

n_0, n_B : electron concentration in base

p_0 : hole concentration in epilayer



Capacitances (low currents)

Transit times (around top of f_T)

Quasi-saturation/Kirk effect (beyond top f_T)

Reverse transit time (hard saturation, negative V_{CB})

Independence of parameters

■ Capacitance values and transit times **do not** influence DC behaviour

■ Base parameters I_S, I_K, τ_B

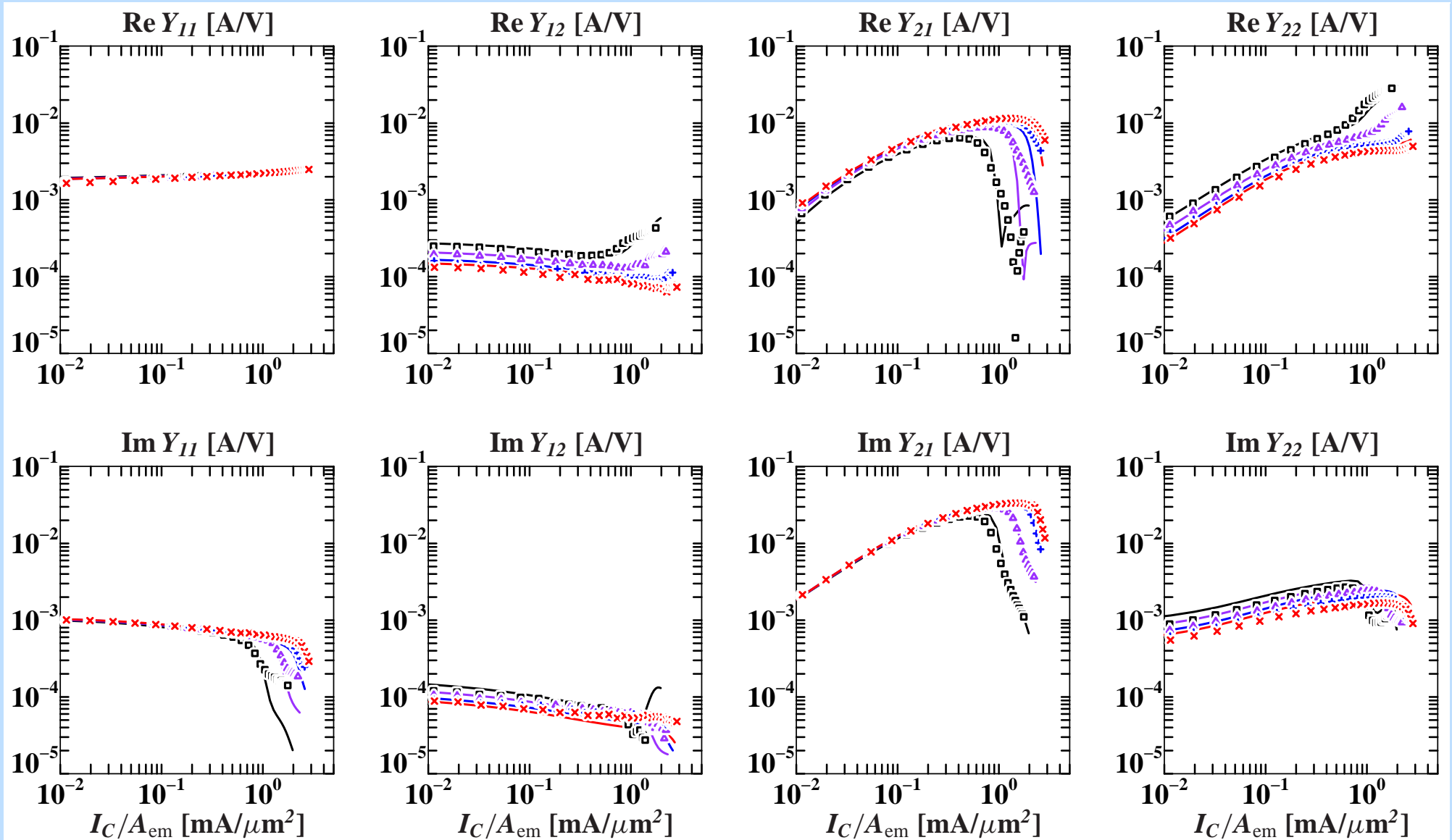
are **separate** from

epilayer parameters $R_{CV}, SCR_{CV}, I_{hc}, \tau_{epi}$

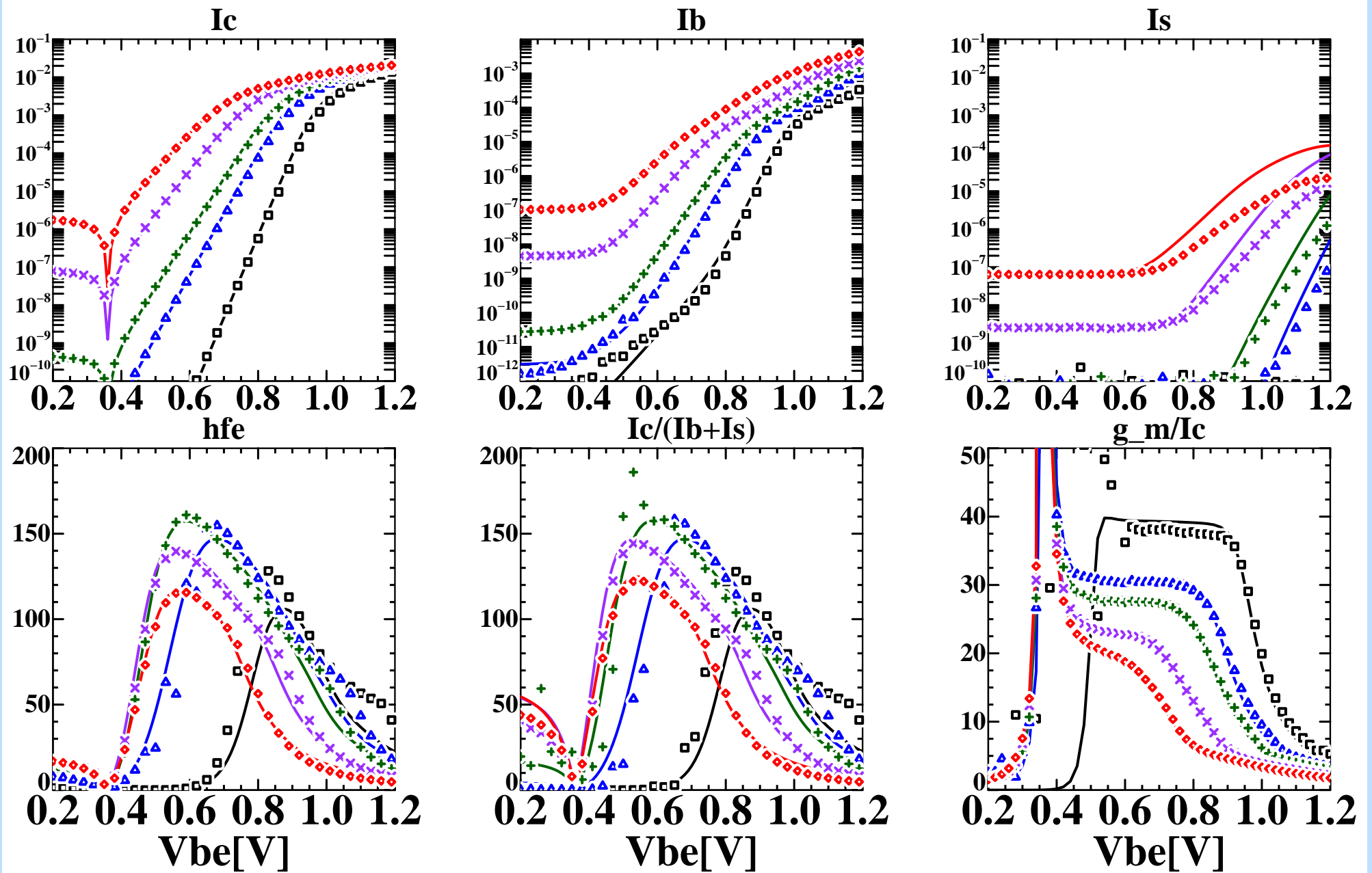
⇒ **Ge** in **base** does not influence **epilayer** parameters

■ Independency simplifies parameter extraction

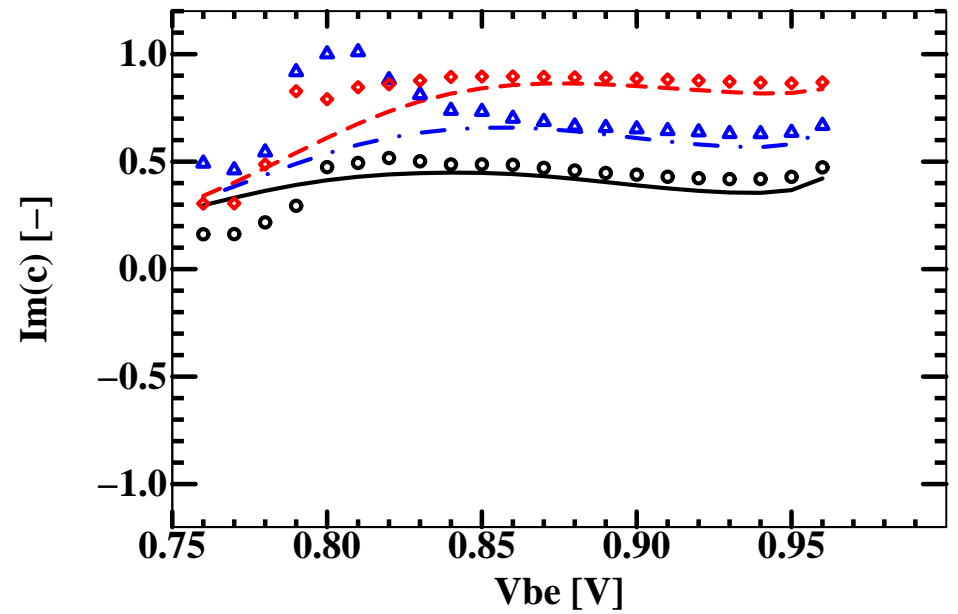
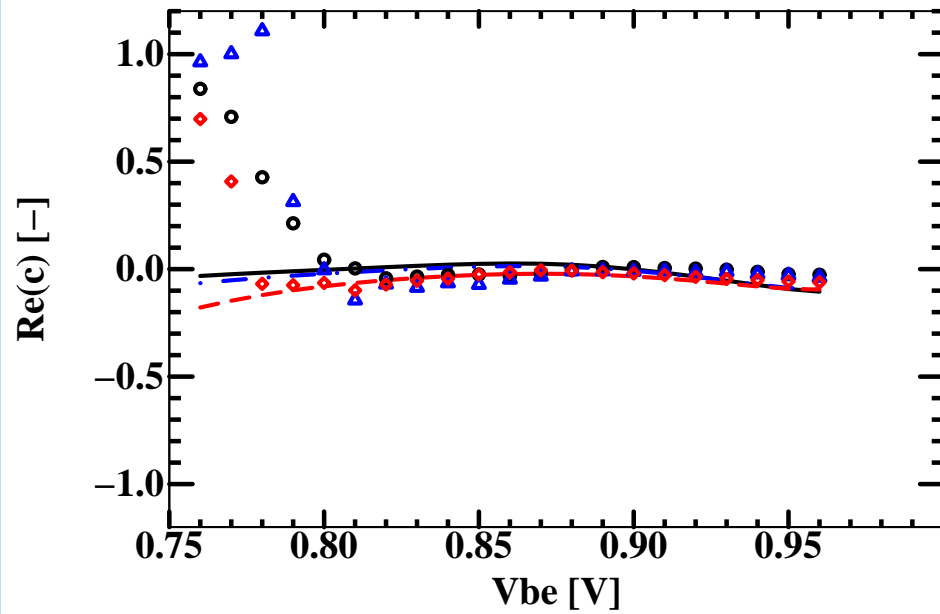
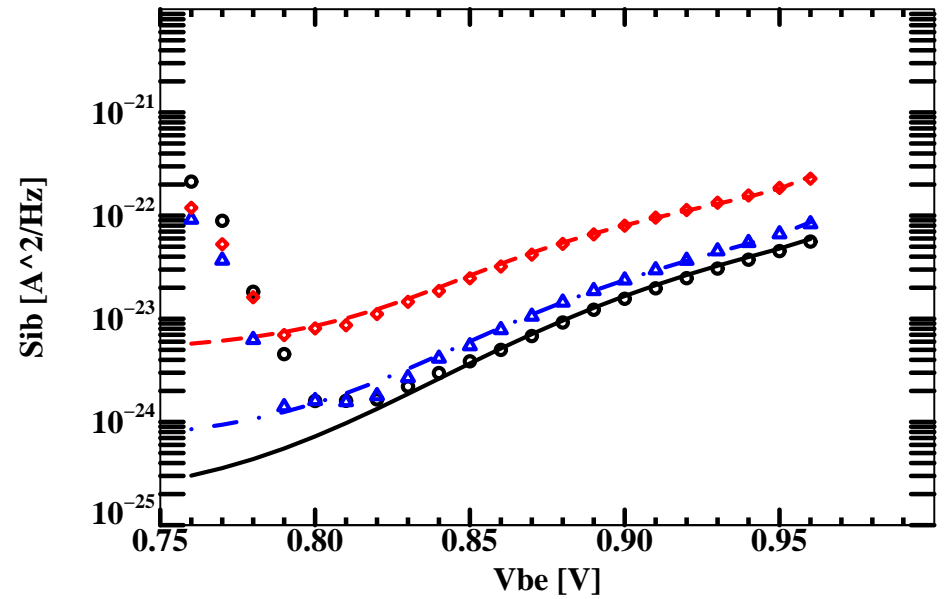
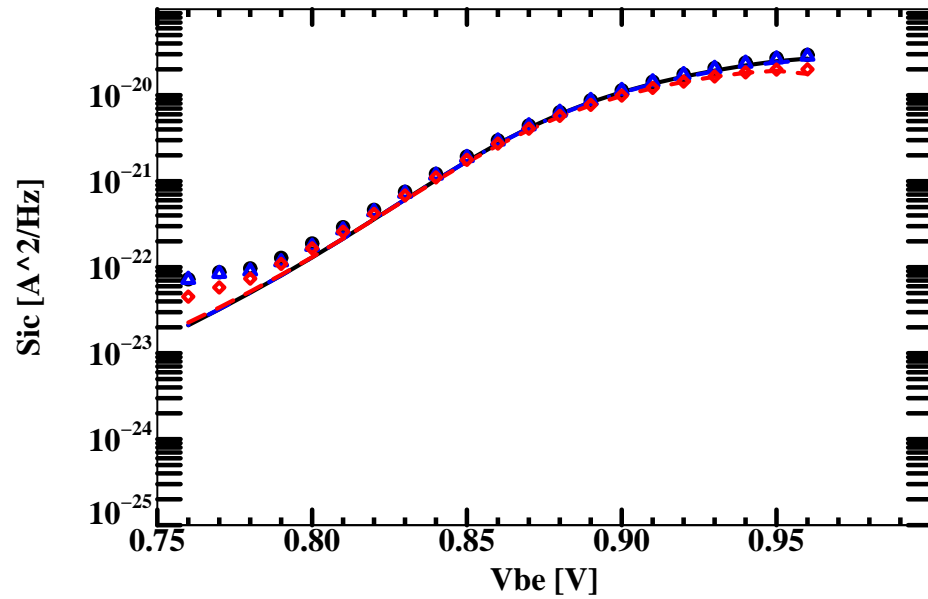
Small-signal parameters $V_{CB} = -0.4, 0, 0.75, 1.5\text{V}$ (Research SiGe)



Temp. scaling $V_{CB} = -0.36V$, $T = -50, 25, 62.5, 137.5, 200^{\circ}C$



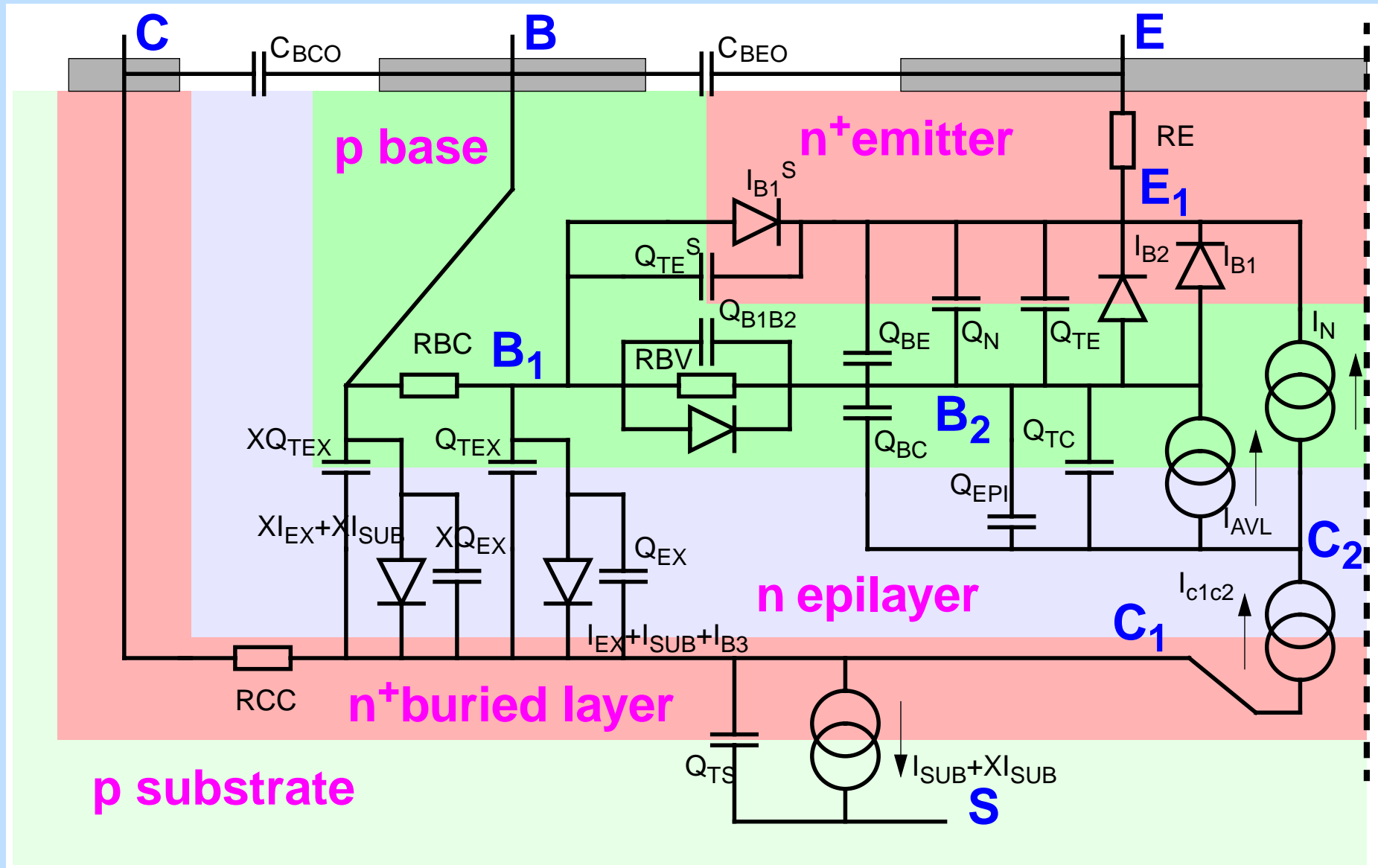
RF noise model ($0.5 \times 20.3 \mu\text{m}^2$, $f = 1, 2, 5.5 \text{ GHz}$, $V_{CE} = 2 \text{ V}$)



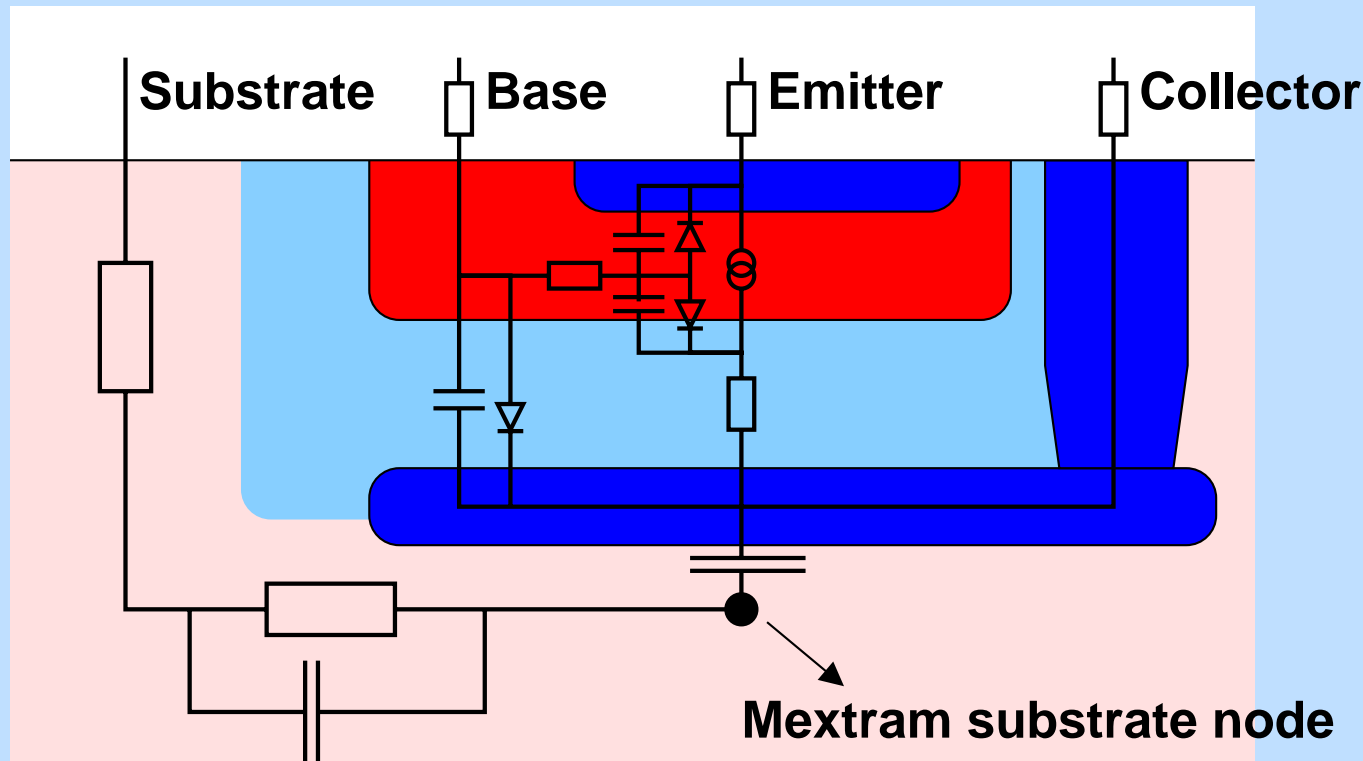
Parameters of Mextram

Forward current modelling	: 25
Reverse current modelling (including PNP)	: 6
Extra parameters used only in charge modelling	: 14
Temperature scaling model	: 14
Self-heating	: 2
Noise model ($1/f$)	: 3
HBT options	: 2
General parameters (level, flags, reference temperature)	: 7
Total	: 73

Equivalent circuit describing the elements of a bipolar transistor



Substrate resistance



Mextram does **not** contain substrate network:

- On-wafer characterization layout differs from final design
- Never complex enough when really needed

List of modelled effects

Modelled better in **Mextram** than in **Spice-Gummel-Poon**

- Current gain (incl. reverse Early effect)
- Early effect (bias dependent) → output conductance
- Reverse behaviour
- Cut-off frequency f_T → all high-frequency behaviour
- Both low and high-frequency distortion
- Large signal modelling → e.g. power amplifiers

List of modelled effects (cont.)

Modelled in **Mextram**, but not in **Spice-Gummel-Poon**

- AC and DC Current crowding in base-resistance
- Substrate effects (parasitic transistor)
- descriptions for emitter-base sidewall region
- descriptions for collector-base extrinsic region
- Splitting of capacitances → extra delay times
- Overlap capacitances

List of modelled effects (cont.)

Modelled in **Mextram**, but not in **Spice-Gummel-Poon**

- **Specific SiGe effects**
- **Self-heating**
- **Weak avalanche, also at high currents**
- **Quasi-saturation and Kirk effect → better HF behaviour**

These last effects are important when **supply** voltage is low

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Neutral base recombination

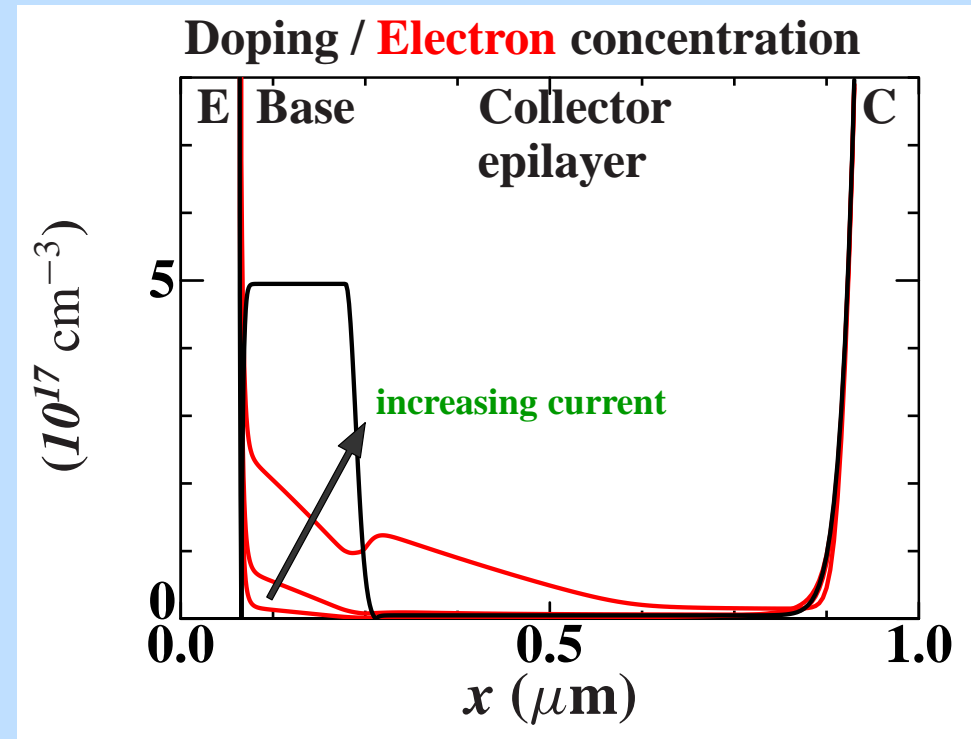
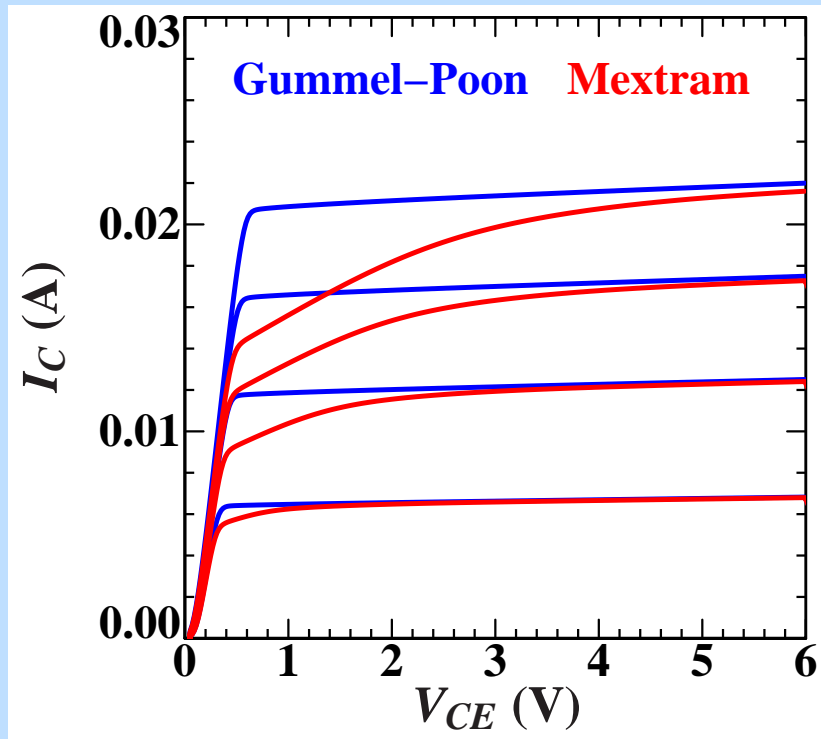
Self-heating

Advanced avalanche modelling: snapback

■ Geometric scaling

■ Status of Mextram 504

Quasi saturation/Kirk effect



For large enough currents **base widening** occurs:

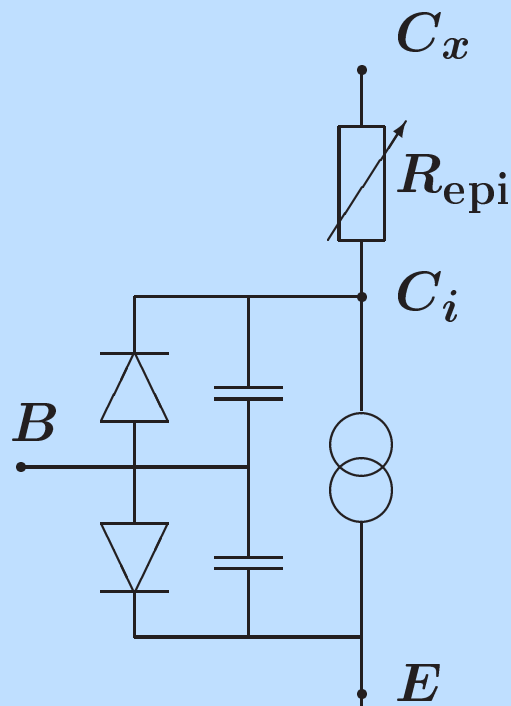
a lot of charge gets injected into the collector epilayer.

Consequence: reduction of current and of cut-off frequency.

Not modelled in Spice-Gummel-Poon model

Modelling quasi-saturation/Kirk effect

The intrinsic part of **Mextram** looks like



Model for **epilayer** resistance:

$$I_{\text{epi}} (V_{BCi}, V_{BCx})$$

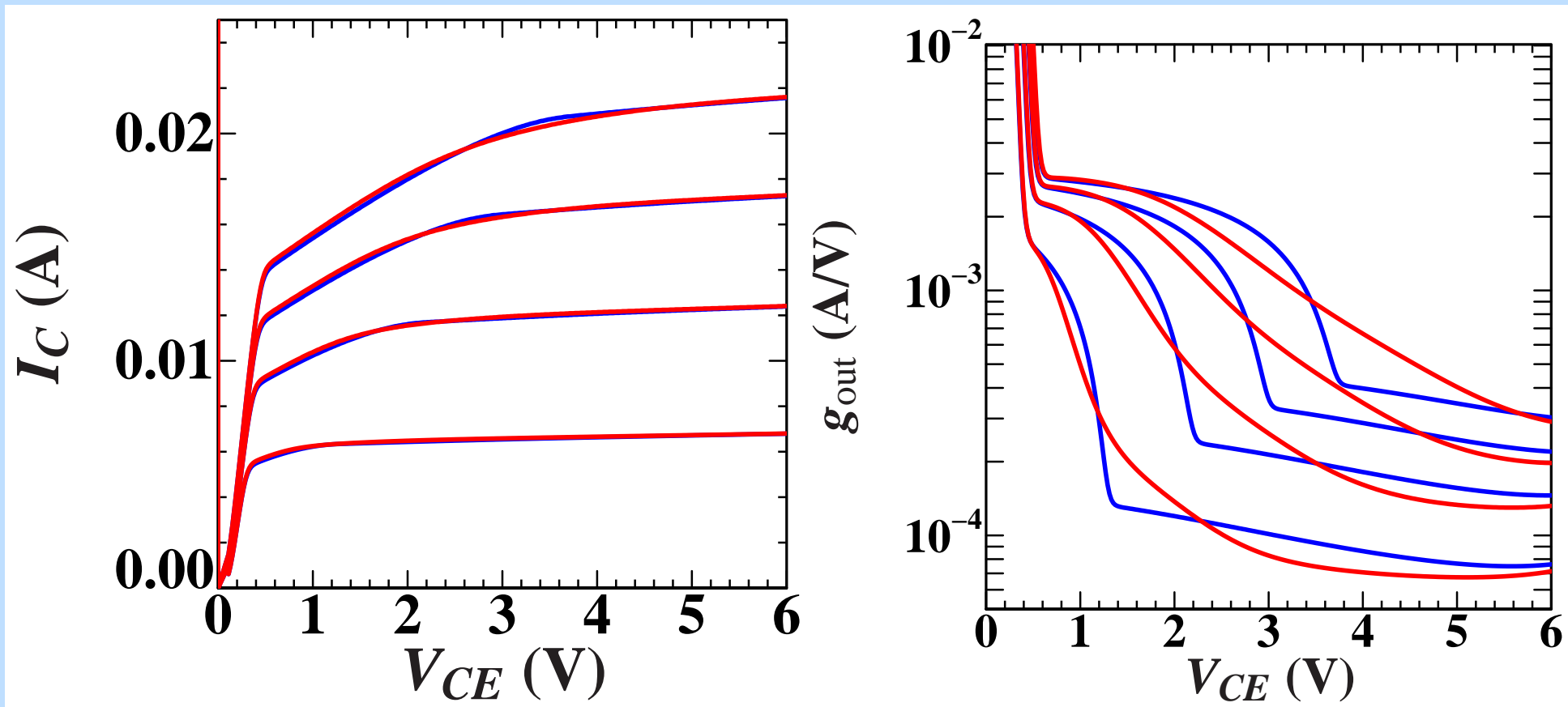
The model contains:

- **Ohmic** resistance
- Resistance modulation due to **excess electrons**
- **Quasi-saturation** (incl. **Kirk** effect)

504 improvement: model comparison

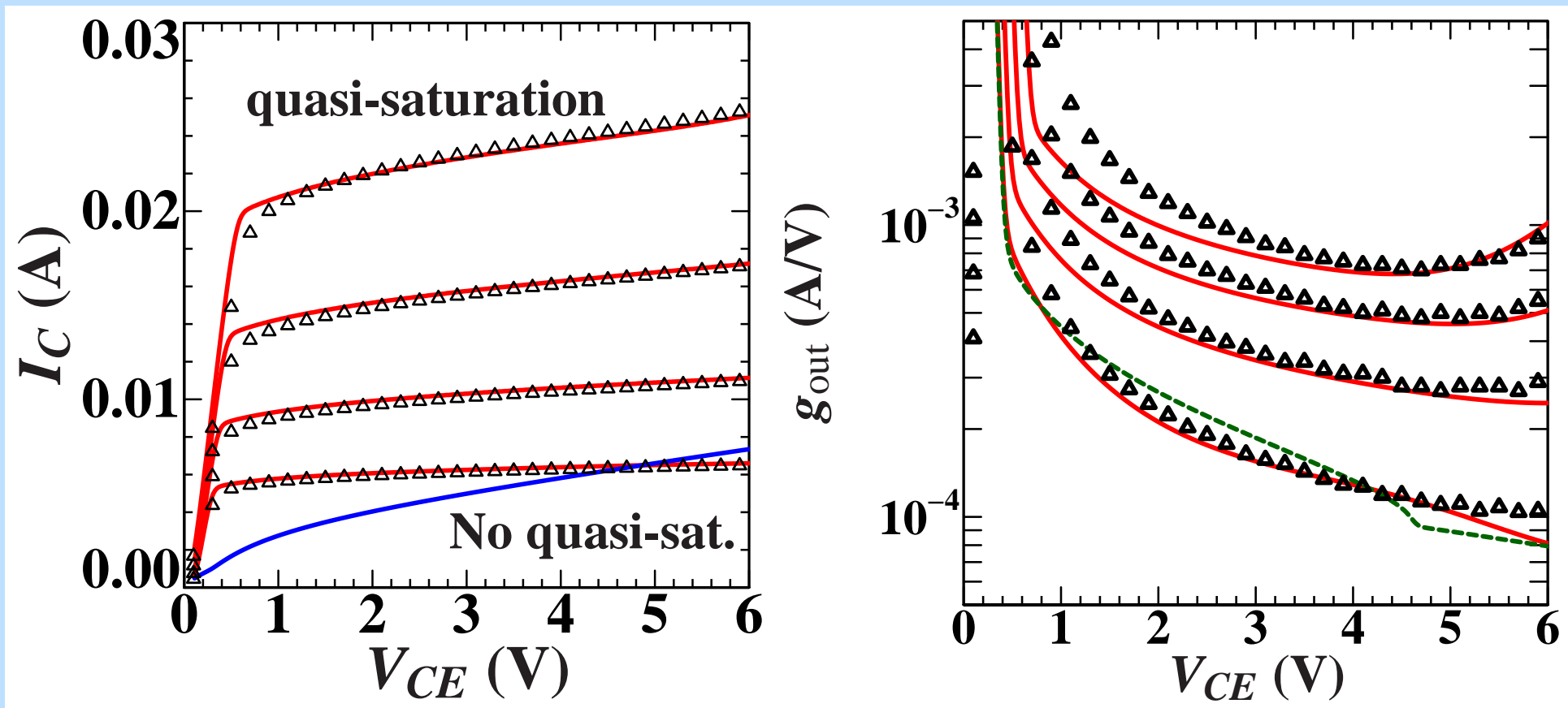
old model: shows kinks in output conductance

Mextram (new model): smoother behaviour



504 improvement: experimental results: (12V BiCMOS process)

Mextram (new model). As one can see: measurements do not show kink at the point where quasi-saturation starts



Blue line: current where quasi-saturation starts

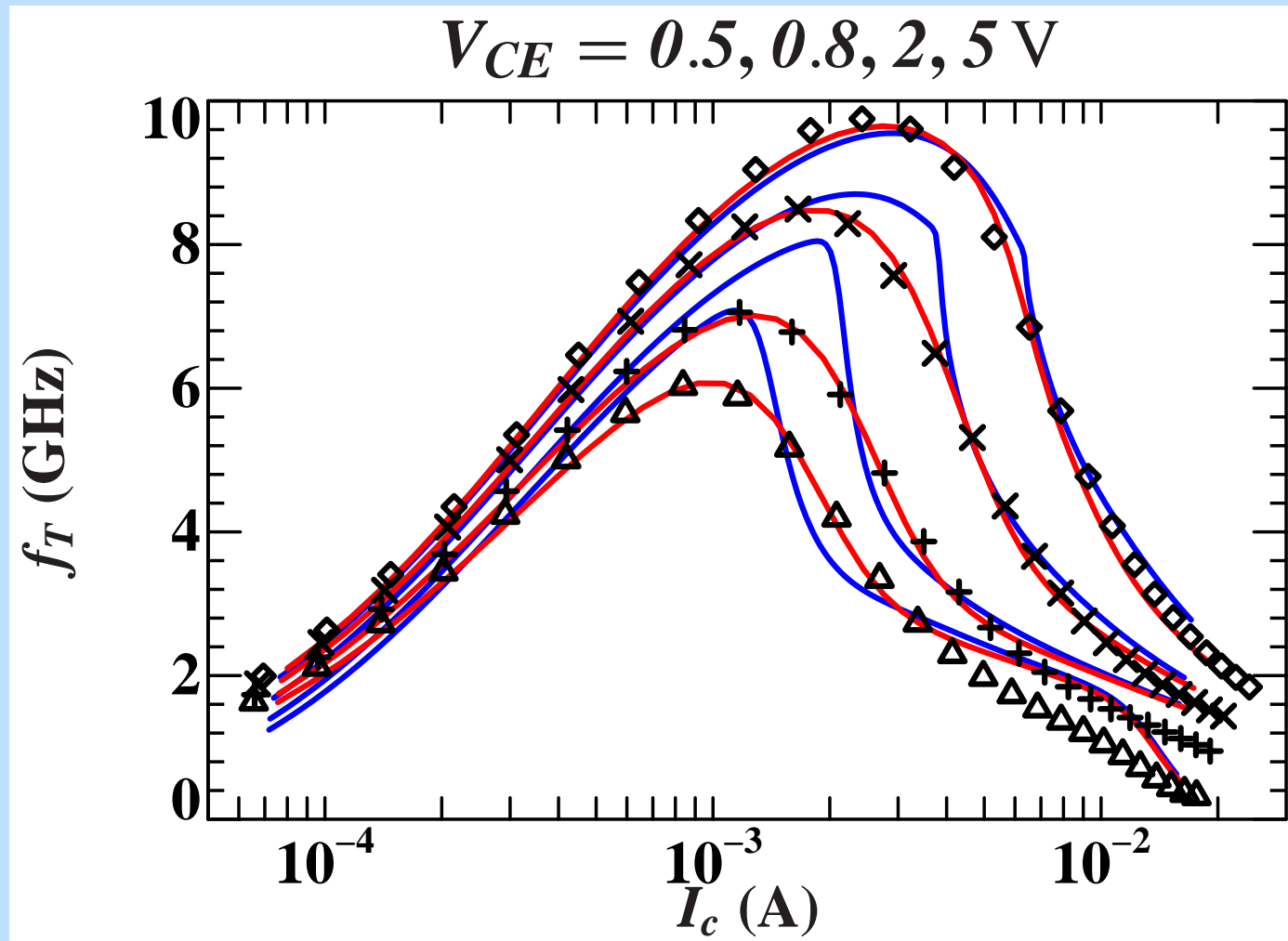
Green line: result from old model

504 improvement: experimental results: (12V BiCMOS process)

old model

Mextram (new model)

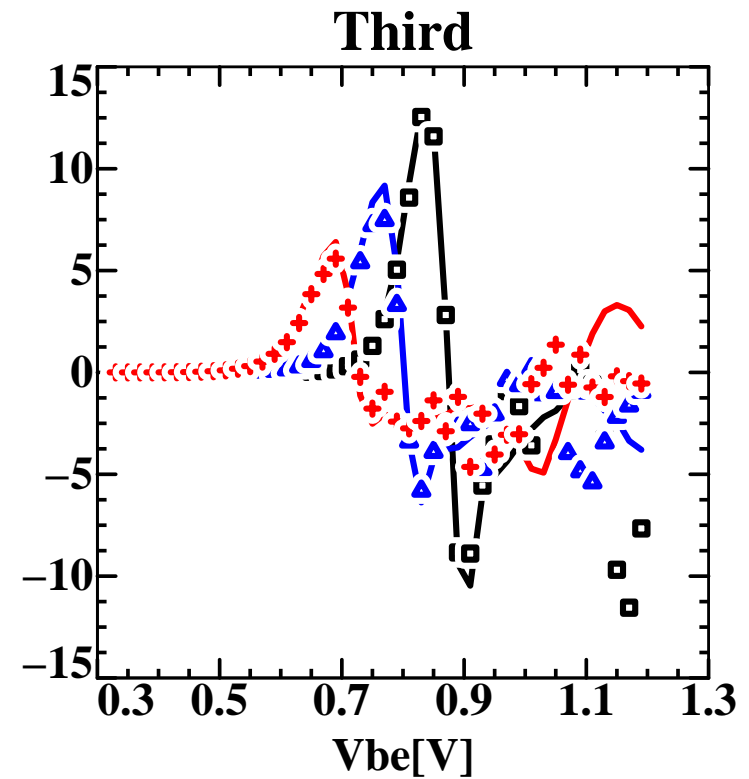
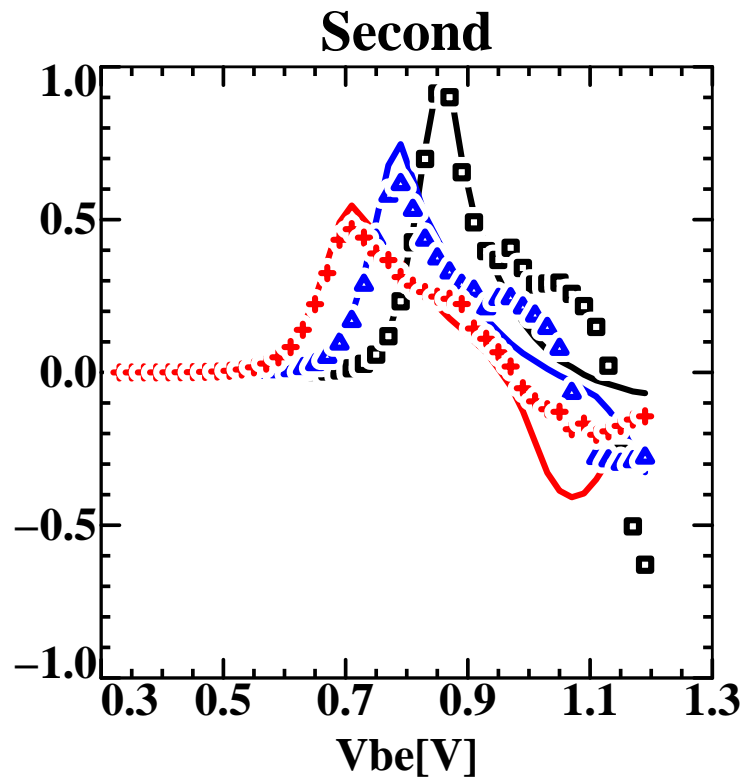
Also for cut-off frequency description improved



504 improvement: experimental results: (12V BiCMOS process)

2nd and 3th derivative of collector current I_C in Gummel plot

Temperature = 25 , 75 , 125 °C



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- Collector-bias dependent base current for SiGe
- Self-heating
- Advanced avalanche modelling at high currents

SiGe transistors

Mextram 504 tested on on various **SiGe** processes

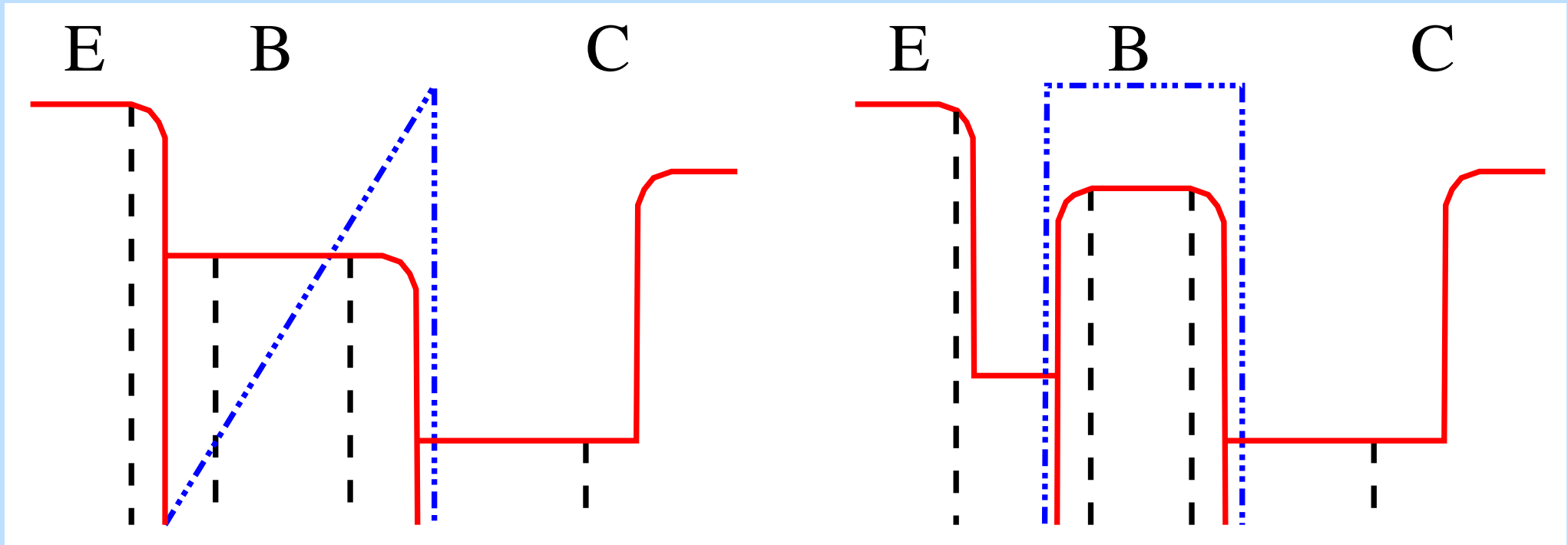
- Device simulations
- Philips (QUBiC4G, various versions from research)
- Infineon, ST (data from international model comparison)
- Temic/Atmel

For most processes no special SiGe options needed, **however . . .**

Graded Ge profile or box-like profile

Doping profile

Ge content



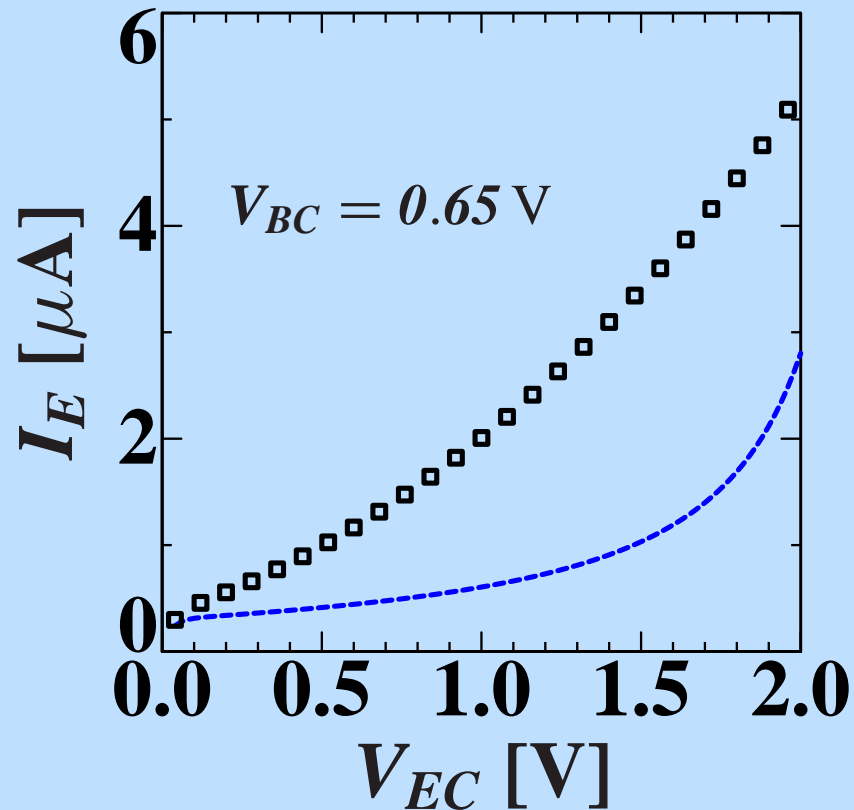
First IBM process and Infineon process have graded Ge-content

Philips has box-like Ge profile

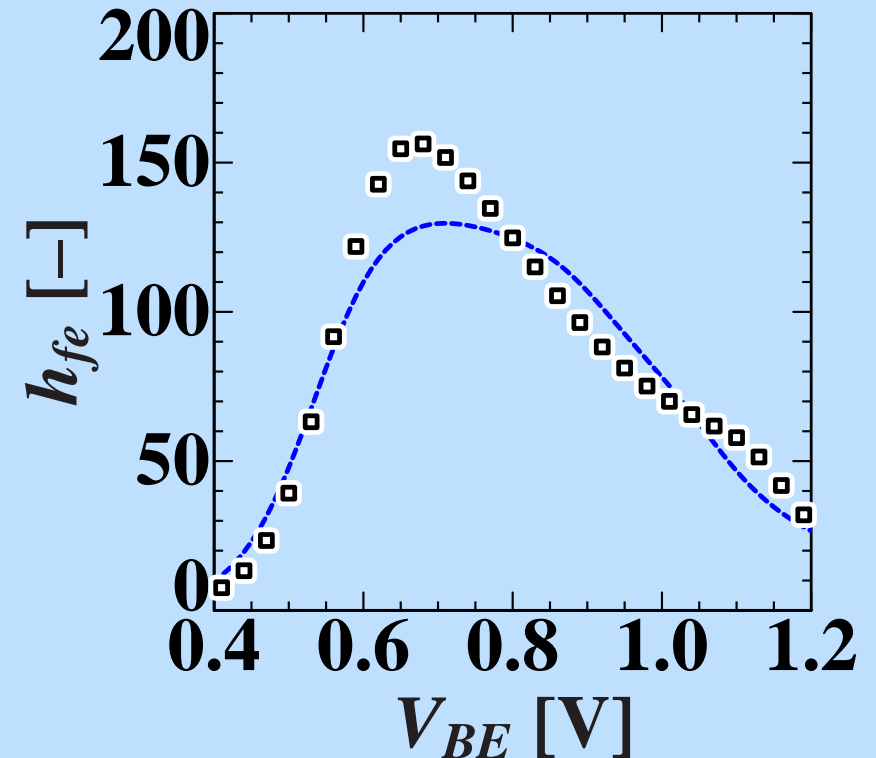
For both cases an option is available in Mextram

Reverse Early effect can be seen in two different measurements:

Reverse Early measurement



Forward current gain

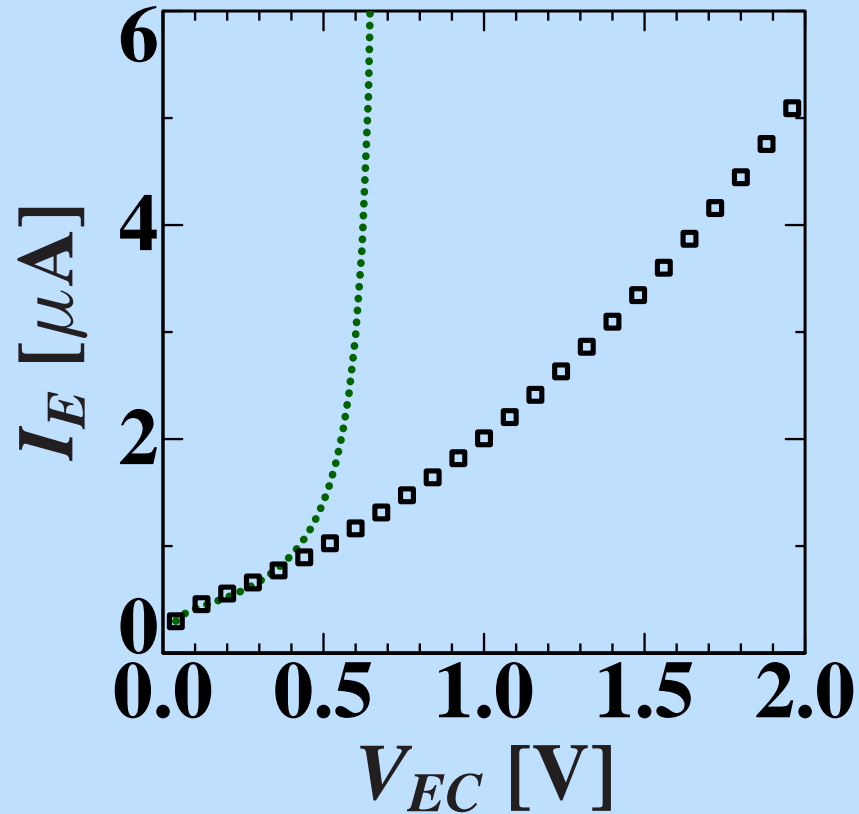


Blue lines are for one parameter set:

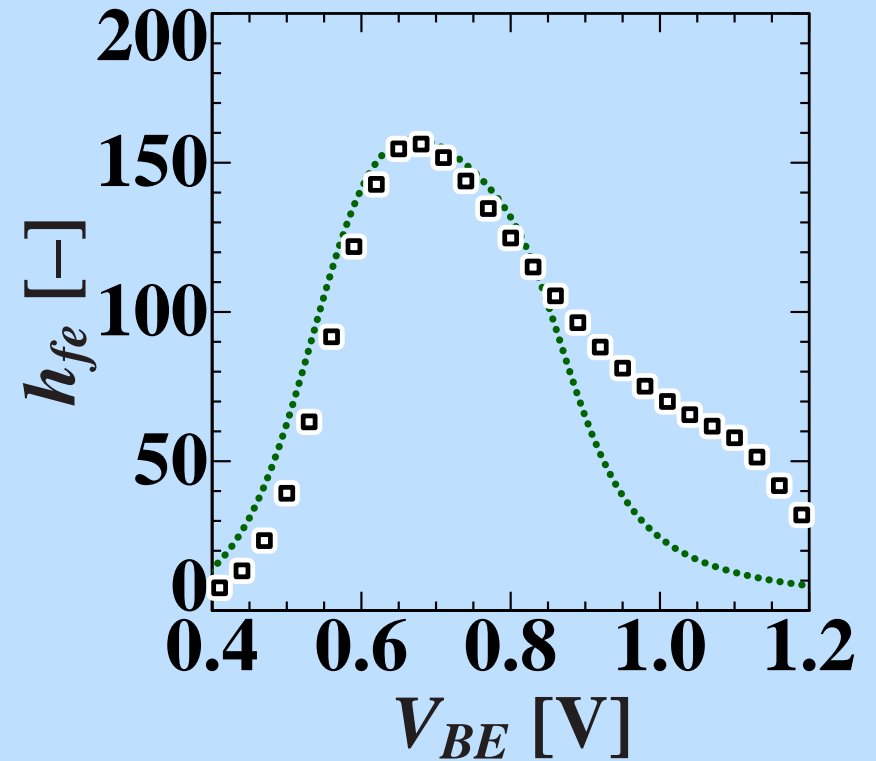
not possible to fit both forward and reverse measurement.

Graded Ge profile: Reverse Early effect

Reverse Early measurement



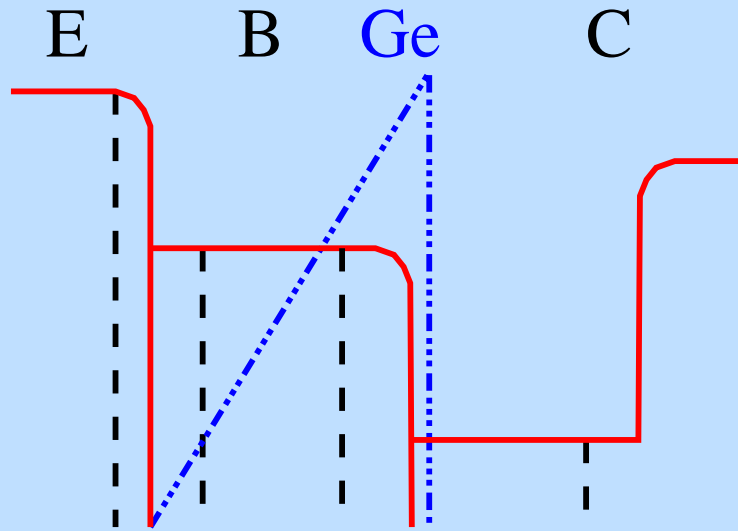
Forward current gain



green lines are for another parameter set:

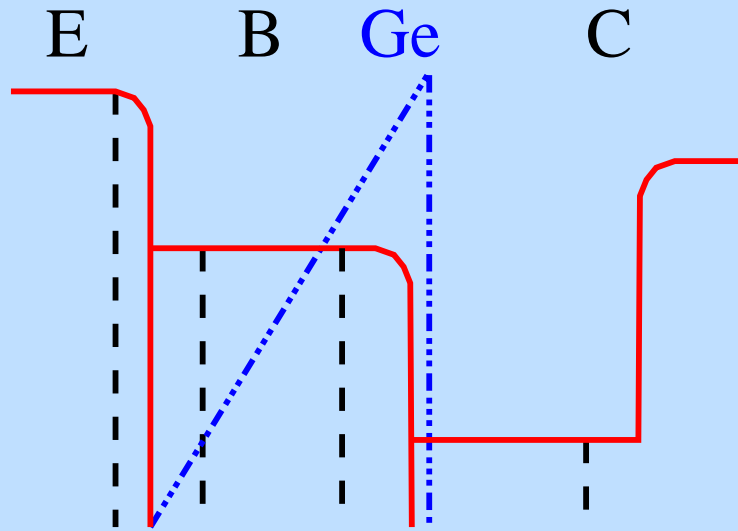
Better result for $V_{EC} < 0.5$ V, but not for larger voltages.

Graded Ge profile: model improvement



$$n_i^2 \propto \exp\left(\frac{x}{W_B} - \frac{\Delta E_g}{kT}\right)$$

Graded Ge profile: model improvement



$$n_i^2 \propto \exp\left(\frac{x}{W_B} \frac{\Delta E_g}{kT}\right)$$

Base charge:
$$\frac{Q_B}{Q_{B0}} \approx 1 + \frac{V_{BE}}{V_{er}} + \frac{V_{BC}}{V_{ef}}$$

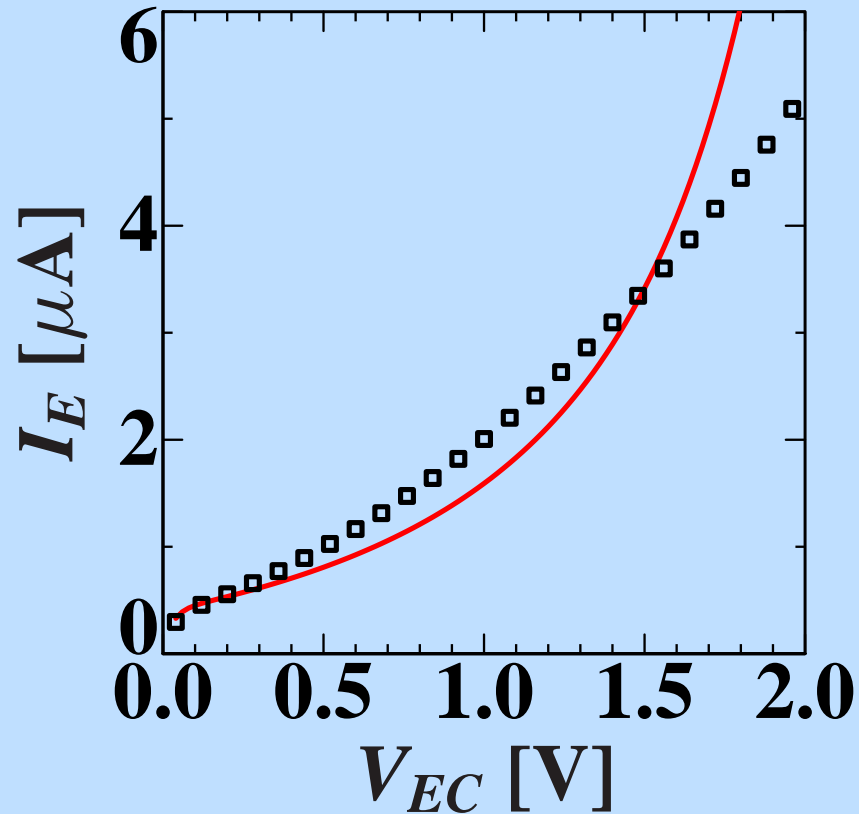
Gummel number:

$$\frac{G_B}{G_{B0}} \approx \frac{\exp\left(\left[1 + \frac{V_{BE}}{V_{er}}\right] \frac{\Delta E_g}{kT}\right) - \exp\left(-\frac{V_{BC}}{V_{ef}} \frac{\Delta E_g}{kT}\right)}{\exp\left(\frac{\Delta E_g}{kT}\right) - 1}$$

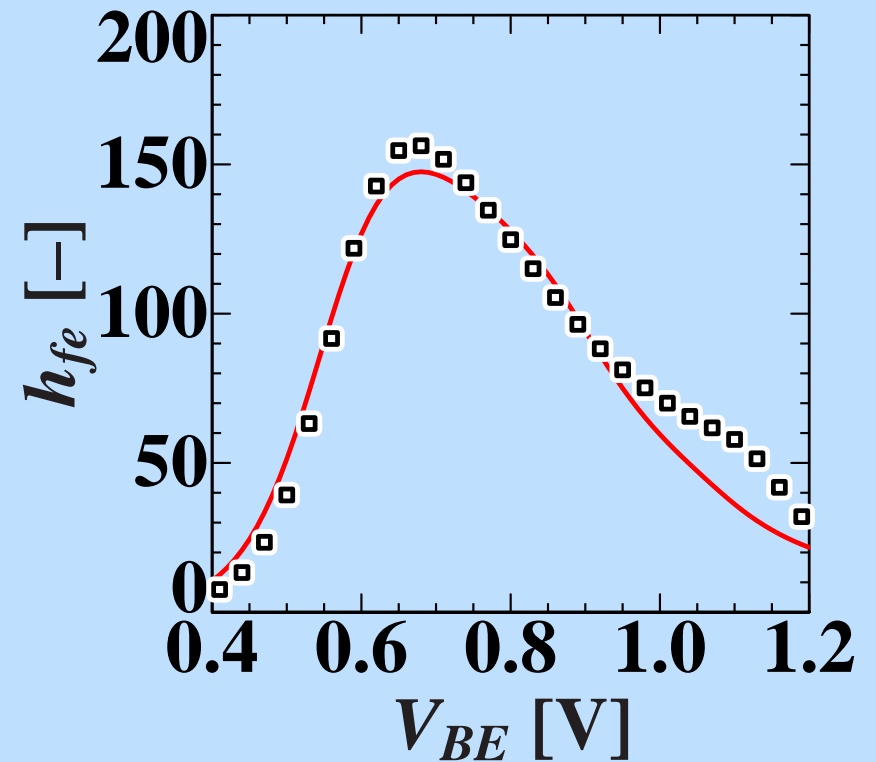
Graded Ge profile: Reverse Early effect

With **new Mextram** option, now including the Ge grading:

Reverse Early measurement



Forward current gain



Effective reverse Early voltage:

large

small

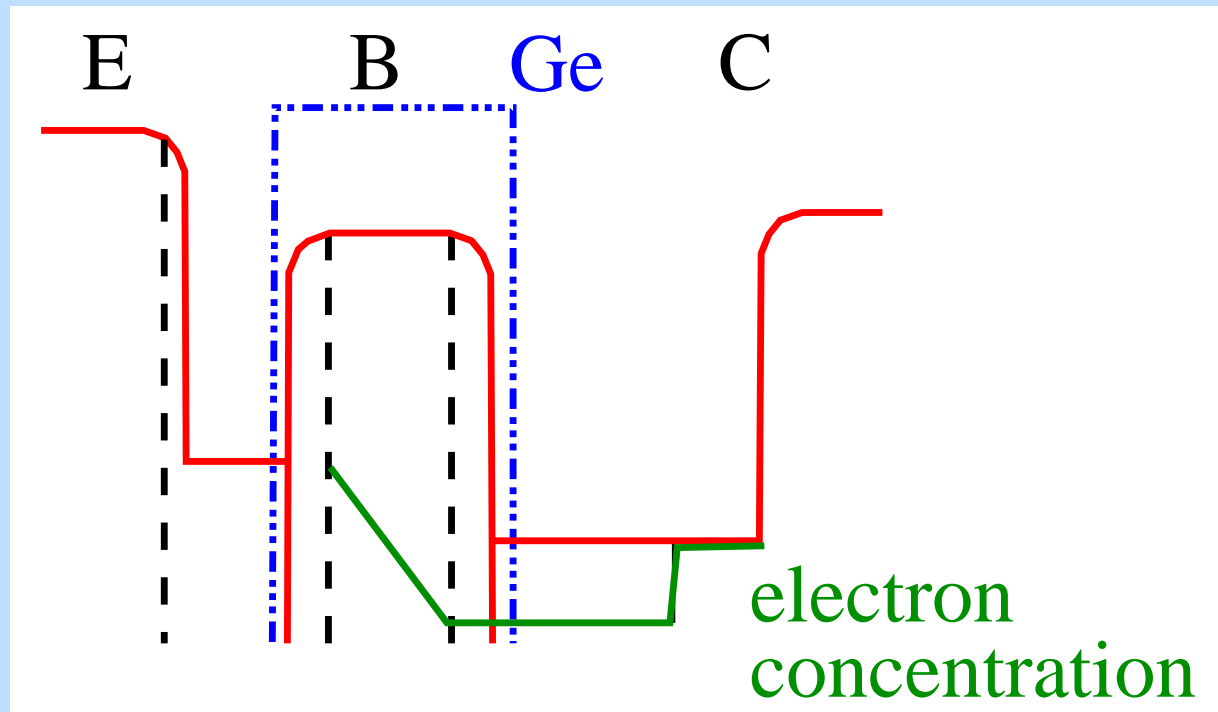
Optional features of Mextram

- SiGe transistor in case of a graded Ge -profile
- Collector-bias dependent base current for SiGe
- Self-heating
- Advanced avalanche modelling at high currents

Modern Ge profile

Doping profile: high base doping, smaller emitter-cap doping

Ge content: square profile

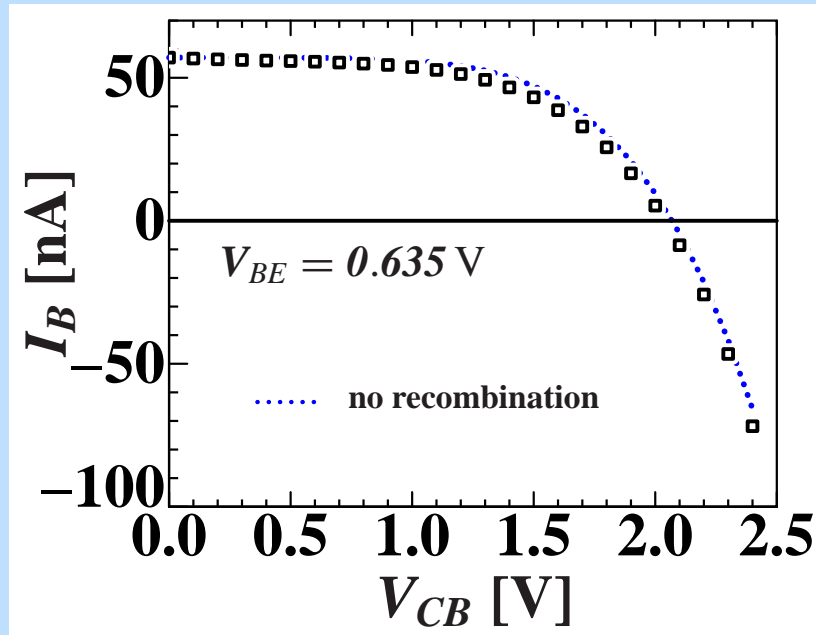


Due to high base doping Neutral Base Recombination (NBR) becomes important.

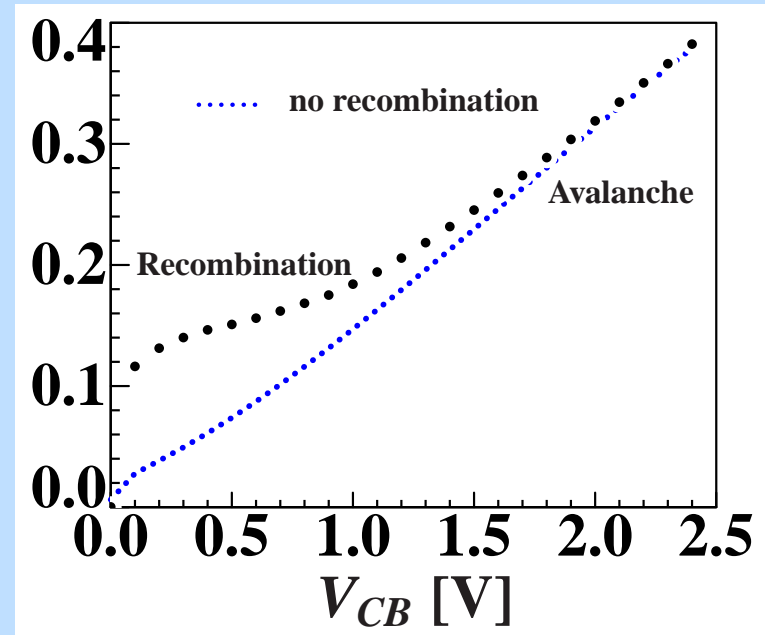
Modern Ge profile: Neutral base recombination (Atmel SiGe)

dotted: without Neutral Base Recombination (NBR)

Base current



$G_{I.I.}^{1/5}$



Generation of Impact Ionisation : $G_{I.I.} = (I_B@0V - I_B)/I_C$

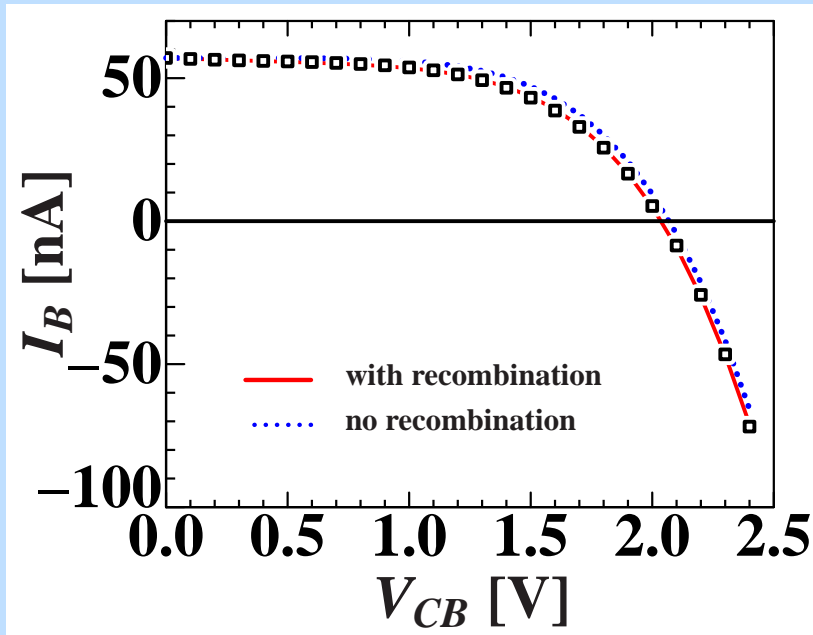
For pure avalanche effect (no NBR): $G_{I.I.}^{1/5}$ is straight line.

Modern Ge profile: Neutral base recombination

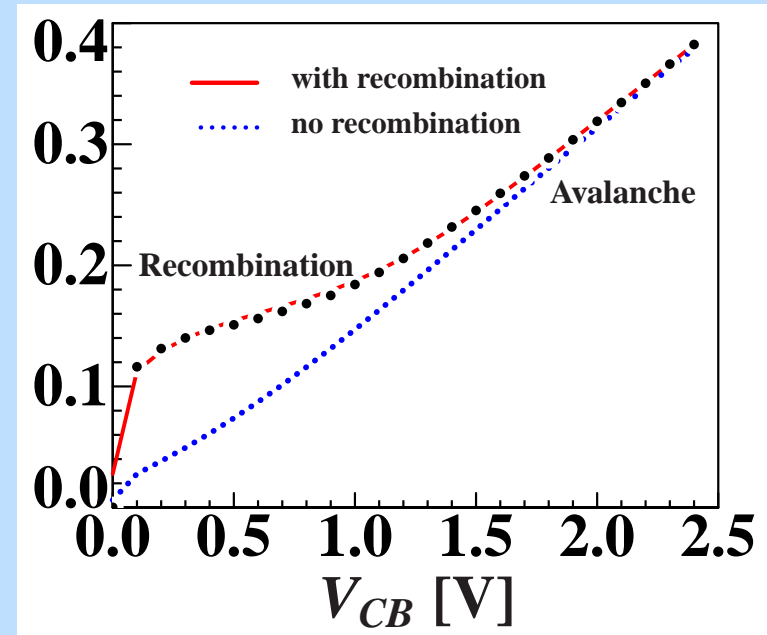
dotted: without Neutral Base Recombination (NBR)

solid: with NBR: new Mextram 504 option, one extra parameter

Base current



$G_{I.I.}^{1/5}$



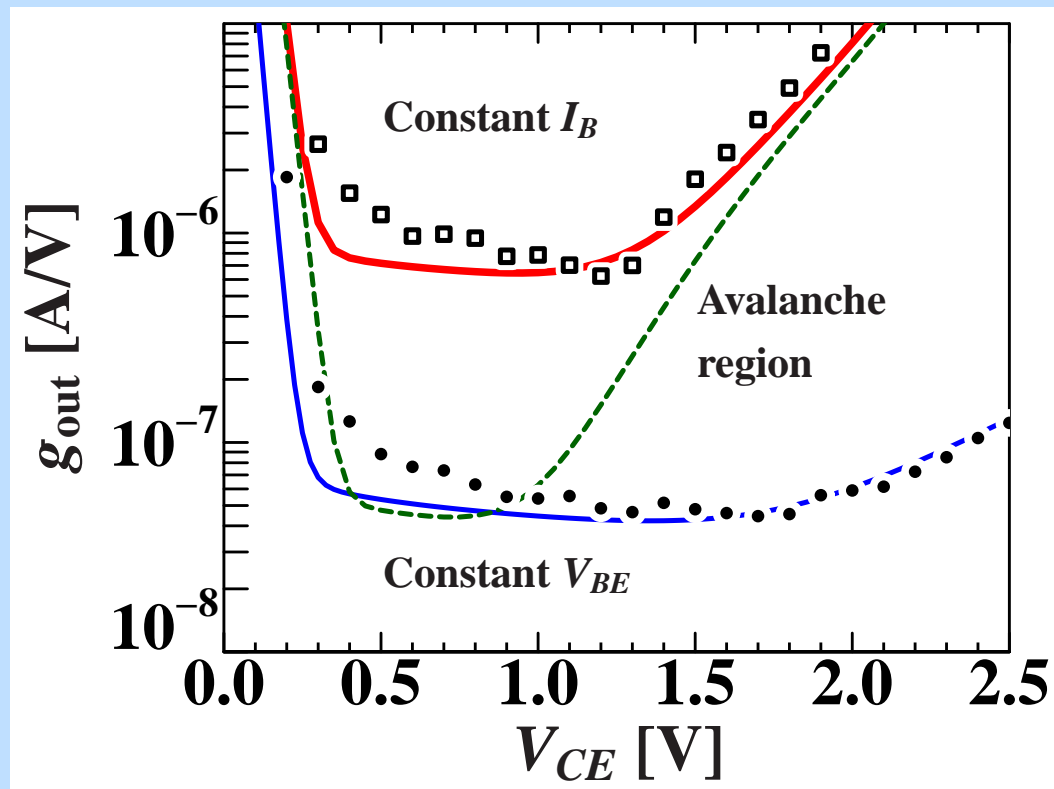
$$\text{New base current: } I_B \simeq \frac{I_s}{\beta_f} \exp\left(\frac{V_{BE}}{V_T}\right) \cdot \left(1 - X_{rec} \frac{V_{CB}}{V_{ef}}\right)$$

Modern Ge profile: NBR effect on output conductance

Constant V_{BE} with or without Neutral Base Recombination (NBR)

Constant I_B without NBR (dashed)

Constant I_B with NBR (new model option)



Optional features of Mextram

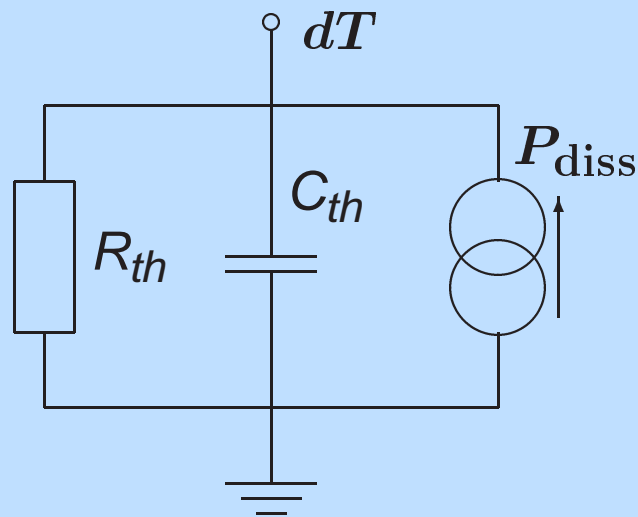
- SiGe transistor in case of a graded Ge -profile
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Self-heating

Self-heating:

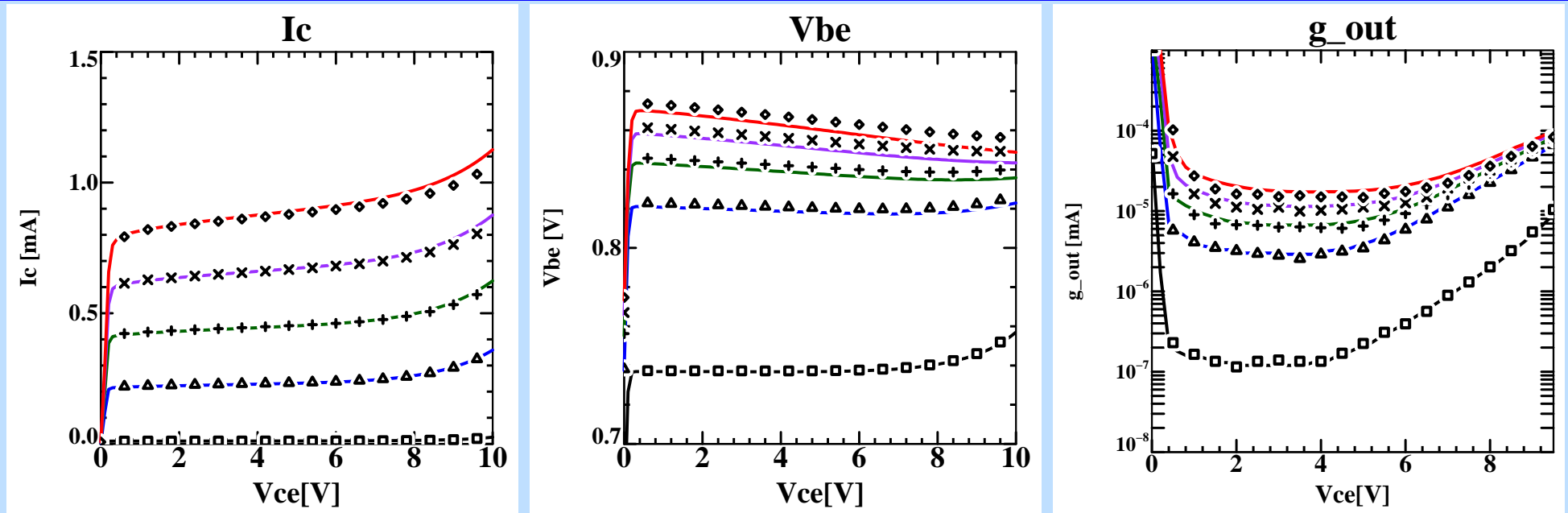
an increase in **temperature** due to **power** dissipation

- Standard extra sub-circuit



- Dissipation P_{diss} : sum over the dissipation in every branch

Selfheating: output characteristic at constant I_B



Mextram 504 is first Philips model with full self-heating
(our simulator allowed a trick to handle self-heating)

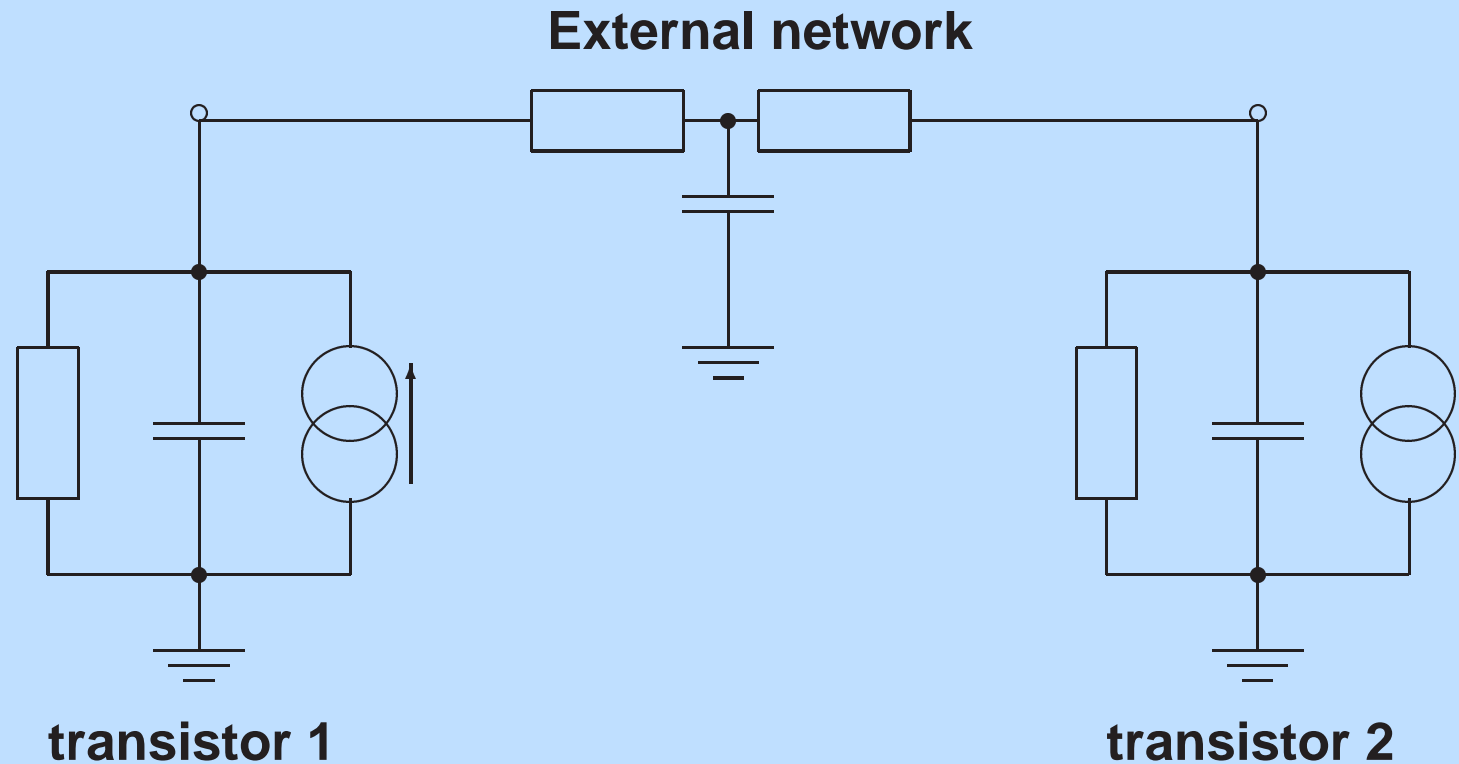
In case of selfheating: V_{BE} **decreases** always

For pure Si transistors: I_C **increases** with V_{CE}

For SiGe transistors: I_C **decreases** with V_{CE}

Selfheating and mutual heating

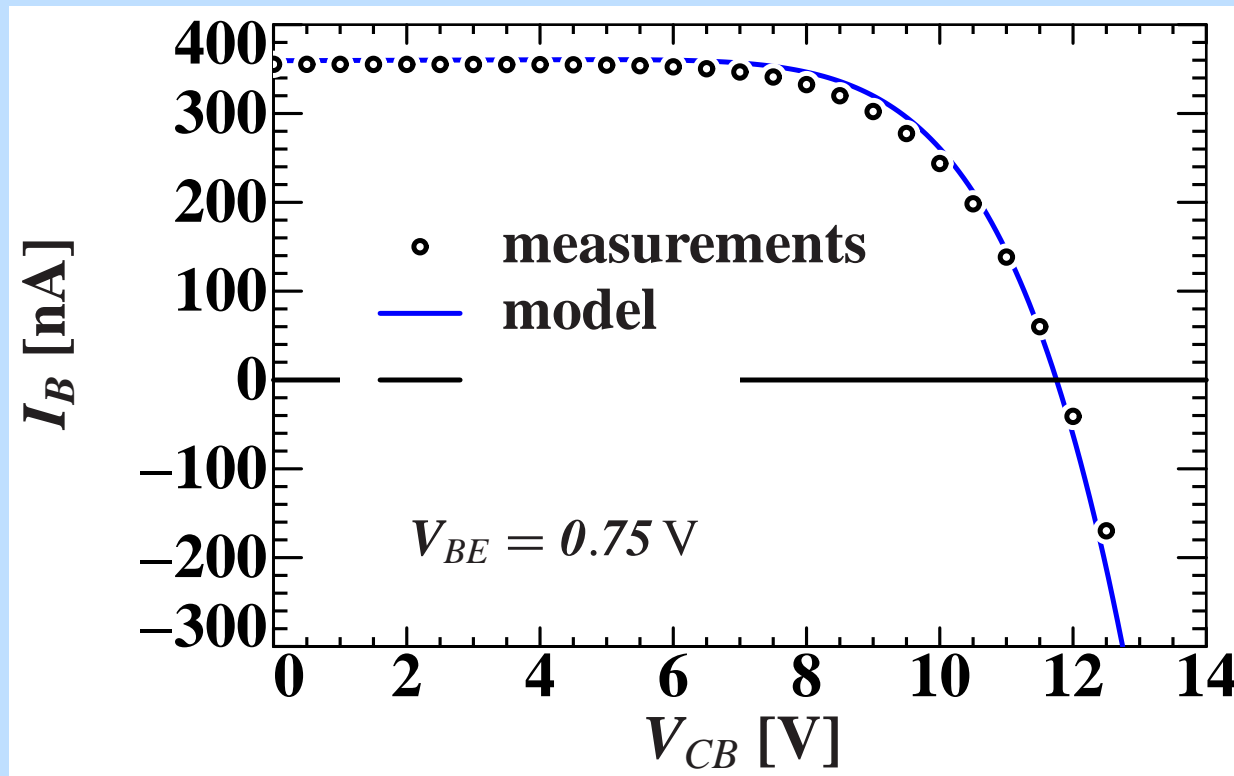
It is possible to model **mutual heating** using an external network



Optional features of Mextram

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Extended avalanche: low currents



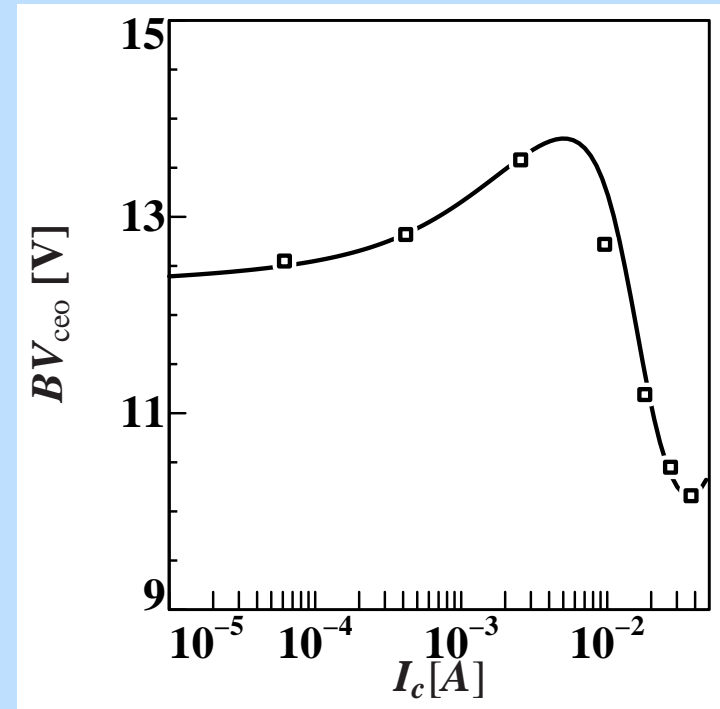
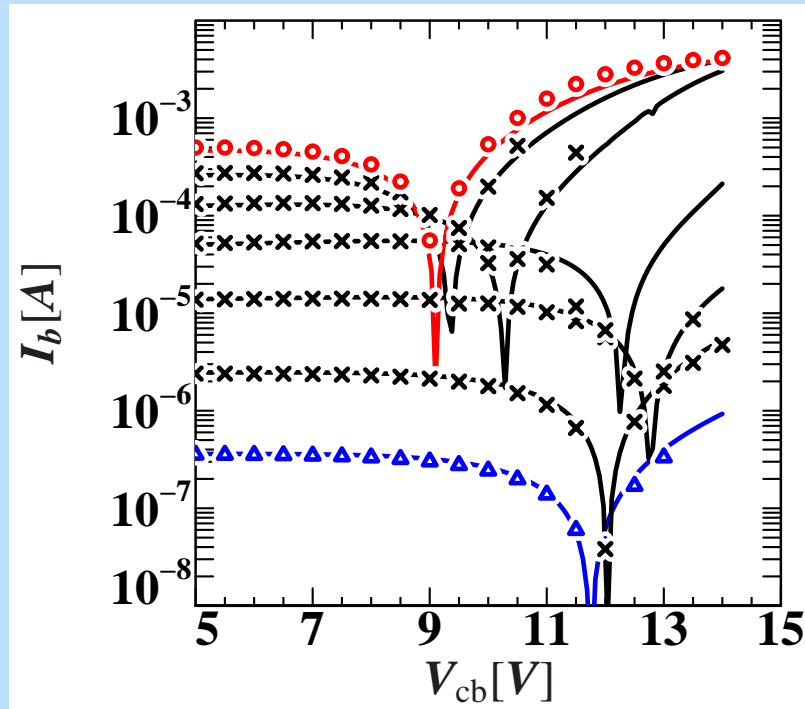
Breakdown voltage BV_{ce0} is where $I_B = 0$ (at constant V_{BE})

For this process $BV_{ce0} \simeq 12$ V.

Extended avalanche: breakdown voltage depends on current level

Base current

$$BV_{ce0} = V_{ce} @ I_B = 0$$



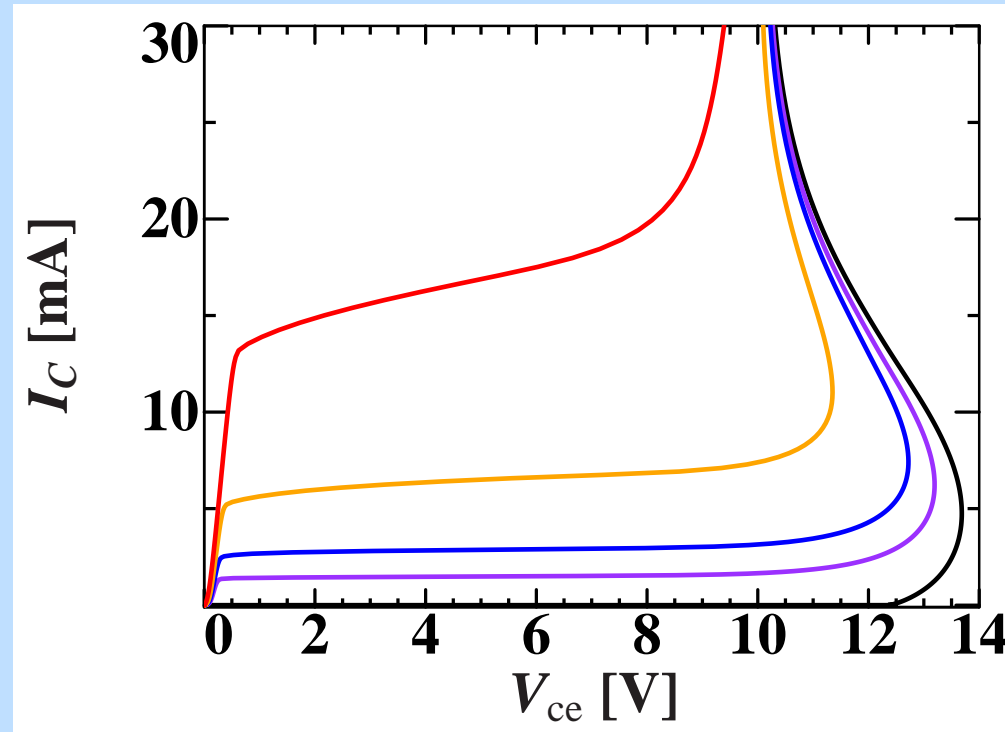
For increasing currents BV_{ce0} normally increases

For high currents BV_{ce0} can decrease again due to Kirk effect

Extended avalanche: snapback

Mextram is the only model capable of describing snapback

output characteristic at constant base current



Snapback is **bad** for convergence → optional feature

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Geometric scaling

The model parameters for a single transistor are called **electrical parameters**

These electrical parameters are a function of **geometry**

Geometry is given by $W_{em} \times L_{em}$, $W_{base} \times L_{base}$ etc.

Example:

$$I_s = I_s^{bottom} W_{em} L_{em} + 2 I_s^{sidewall} (W_{em} + L_{em})$$

$\Rightarrow I_s^{bottom}$ and $I_s^{sidewall}$ are **unity parameters**

Geometric scaling

MOS transistors

Miniset

→ Electrical parameters and temperature scaling

Maxiset

→ Geometry scaling parameters

Bipolar technologies have more geometric variations

Bipolar transistors

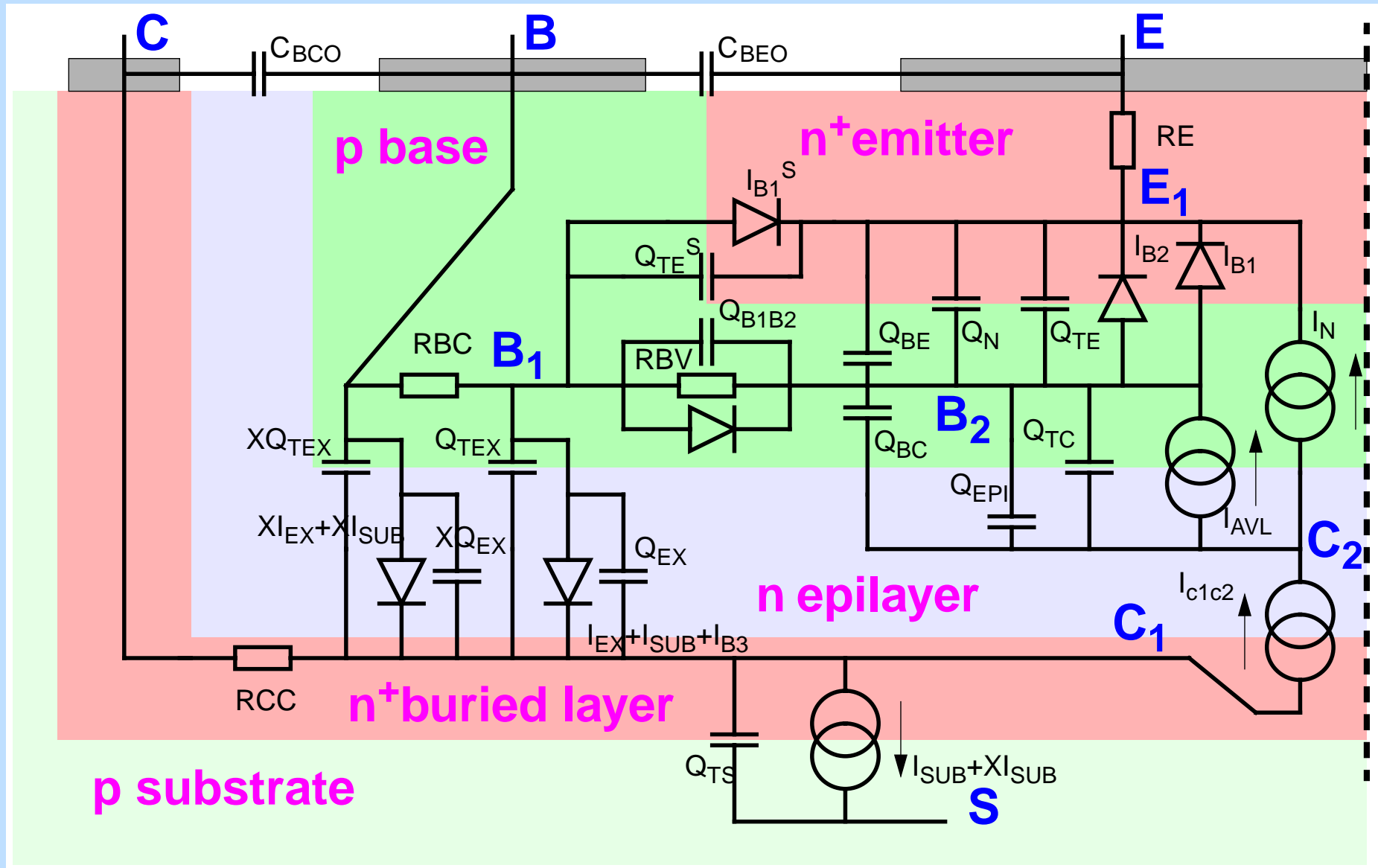
Within Mextram

→ Electrical parameters and temperature scaling

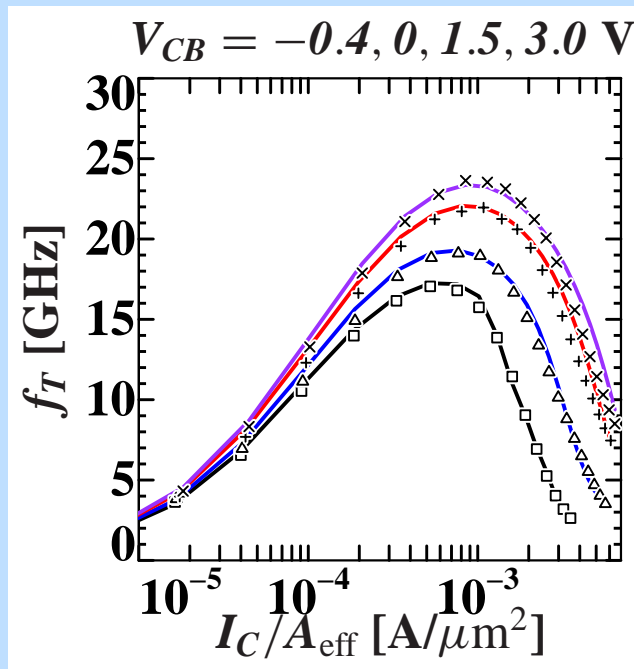
Outside of Mextram

→ Geometry scaling

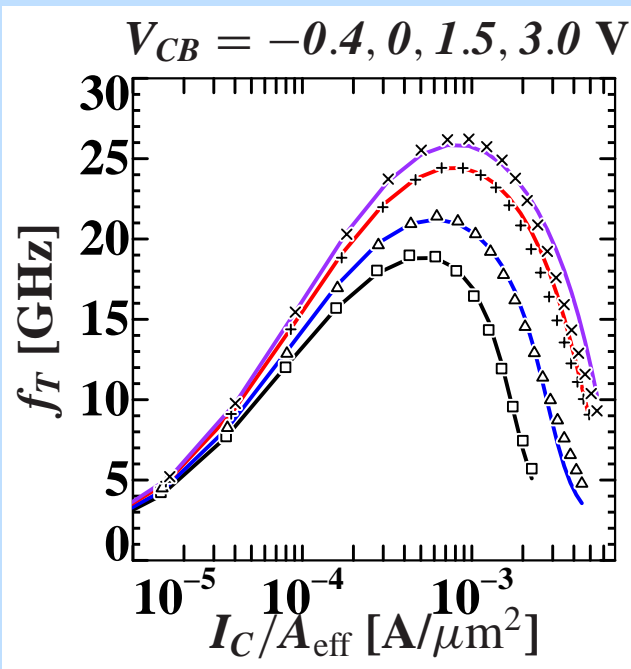
Equivalent circuit describing the elements of a bipolar transistor



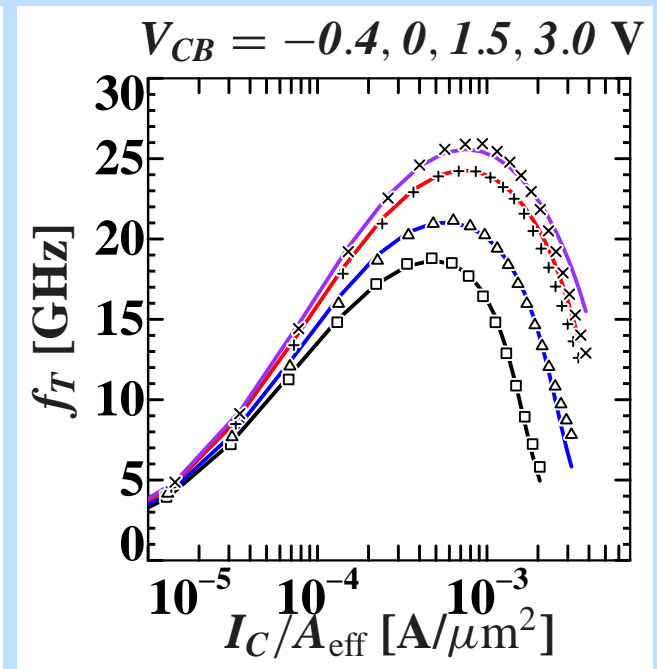
Example: cut-off frequency f_T (0.35 μm BiCMOS)



$0.7 \times 1.4 \mu\text{m}^2$



$0.7 \times 5.6 \mu\text{m}^2$



$0.7 \times 20.0 \mu\text{m}^2$

→ a designer is free to choose **any** length within layout rules.

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Status of Mextram 504

Companies **using** Mextram:

- Philips (of course), TSMC, TI

Companies **evaluating** Mextram:

- Analog Devices, Samsung, IBM

Mextram is **implemented** in (as far as we know):

Spectre (Cadence) (DLL: on our web—4.4.6: Dec. 2001)

HSpice (Synopsys/Avant!) (2002)

ADS (Agilent) (March 2002)

Eldo (Mentor Graphics) (March 2001)

Pstar (In-house) (4.1, June 2001)

Summary

Mextram is an advanced compact bipolar model:

- is based on **physics**
- can be used for **analogue** and **digital** applications
- special attention is paid to (higher-order) **derivatives**
- describes the various **regions** of the transistor
- contains **temperature** scaling and can be scaled **geometrically**

Summary (cont.)

- Mextram gives **excellent description** of
 - **Early** effect and output conductance
 - **High-current** effects
 - **High-frequency** behaviour
 - **Noise** behaviour

- Mextram contains **features** for
 - Non-constant **Ge profiles**
 - **Early** effect on the **base** current
 - Extended **avalanche** for high currents
 - **Self-** and **mutual heating**

- Mextram is **implemented** in various commercial simulators

More information

Our **Web-site** [1] contains:

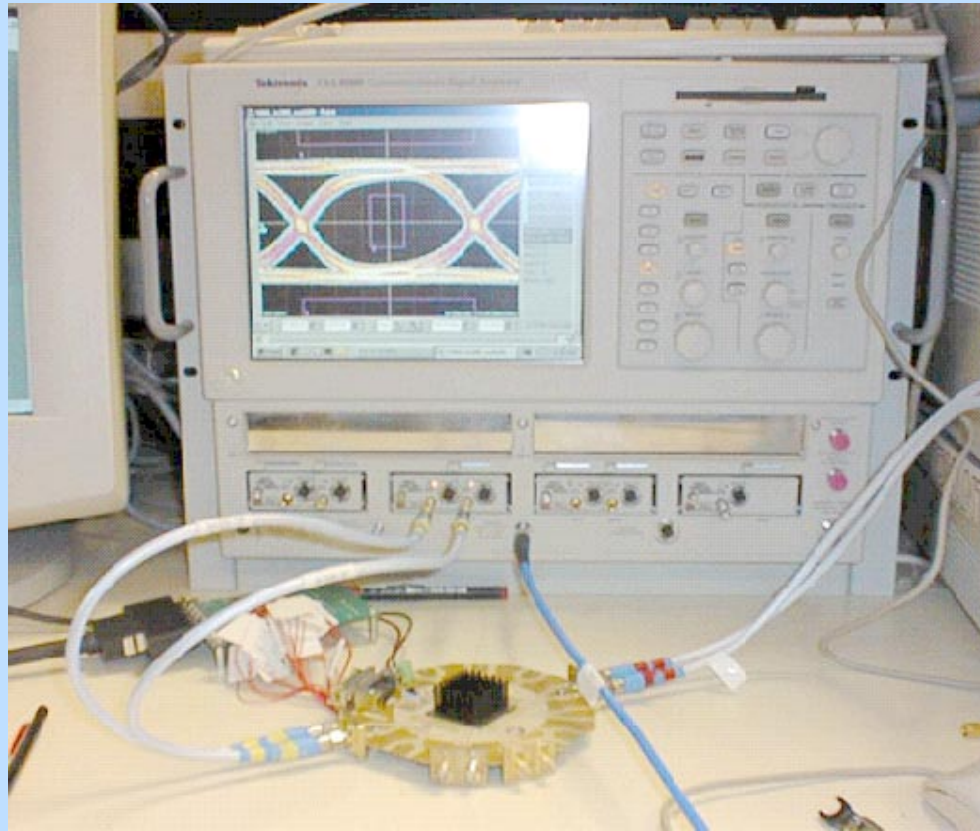
Documentation

- **Model definition [2]**
- **Derivation of all equations [3]**
- **Parameter extraction [4]**
- **Comparison between Mextram 503 and Vbic 95 [5]**
- **A number of publications like [6, 7, 8, 9, 10]**
- **A number of presentations like [11,12,13,14]**

Source code

- **Full Mextram 504 code including simple solver**
- **Spectre Model Kit (dynamically linkable library)**

Real example



World's first 20×20 10Gb/s crosspoint switch (optical networking)

Designed using Mextram (first time right)

Based on 1D simulations combined with measured scaling rules

References

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7. J. C. J. Paasschens, W. J. Kloosterman, R. J. Havens, and H. C. de Graaff, “Improved compact modeling of output conductance and cutoff frequency of bipolar transistors,” *IEEE J. of Solid-State Circuits*, vol. 36, pp. 1390–1398, 2001.

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13. J. C. J. Paasschens, "Mextram 504," Presentation CMC, Dec. 9, 1999. See Refs. 1 and 20.
14. J. C. J. Paasschens, "Mextram 504, experimental results," Presentation CMC, March 27, 2000. See Refs. 1 and 20.